



SiC Power Device and Material Technology For High Power Electronics

**High Megawatt Power Technology
R&D Roadmap Workshop**

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David Grider

Cree, Inc.

**4600 Silicon Drive
Durham, NC 27703; USA**

Tel.: 919-313-5345

Mobile: (919) 201-3590

Email: david_grider@cree.com

**Support Provided By -
DARPA - Sharon Beermann-Curtin
ARL - Skip Scozzie
AFRL - Jim Scofield**

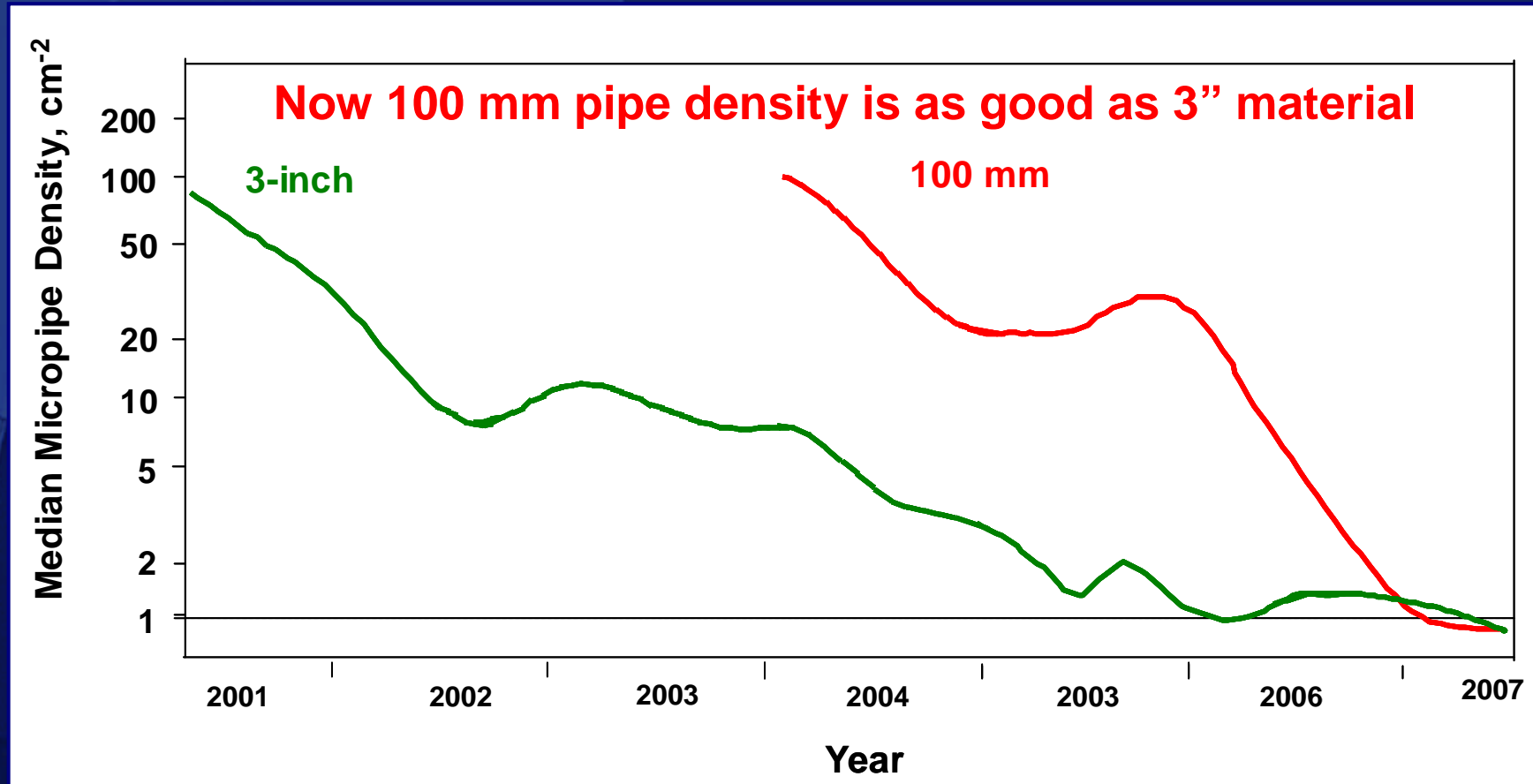
Cree Excellence in SiC Materials and WBG Device Manufacturing



- **World's Largest Fabricator of GaN-on-SiC**
 - Ship > 15 million devices per day
- **World's Largest Supplier of SiC substrates**
 - Supply 95% of the world's supply of single crystal SiC
- **Vertical Integration**
 - Crystal Growth => Device Fabrication => Package/Test

Dramatic Reduction in 4HN SiC Substrate Micropipe Densities

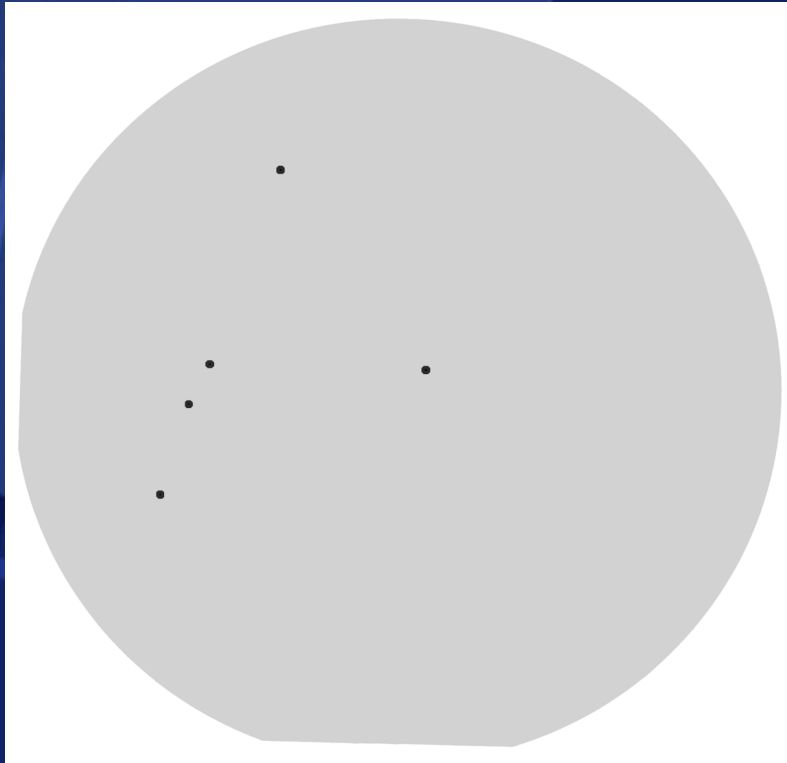
Monthly median micropipe density of 4H n-type wafers is $< 0.8 \text{ cm}^{-2}$



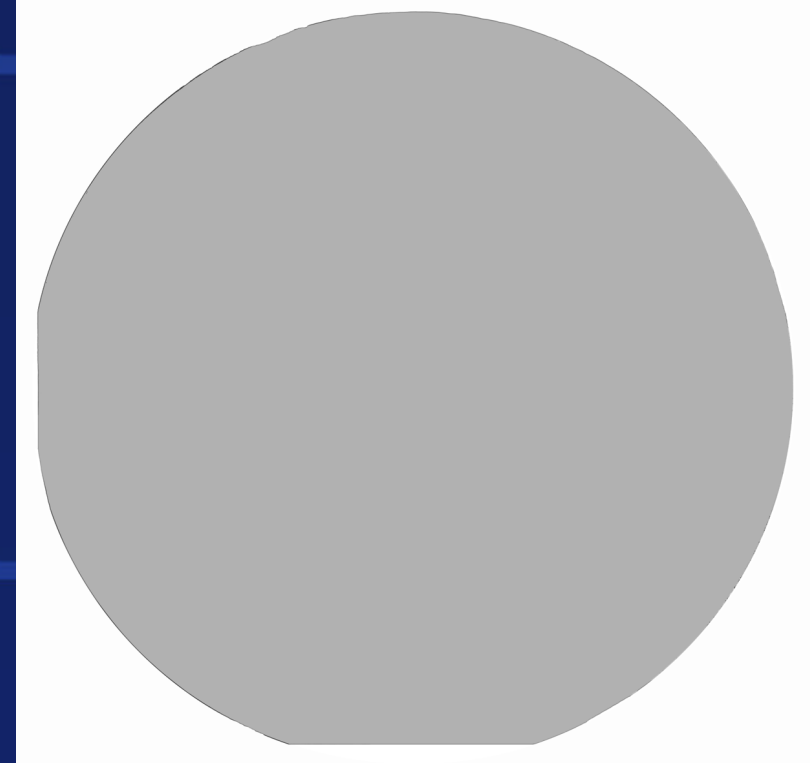
100-mm work supported by ARL MTO (W911NF-04-2-0021) and DARPA (N00014-02-C-0306)

100 mm 4HN-SiC Substrate Quality

Almost Double the Area of a 3-inch 4HN-SiC Wafer



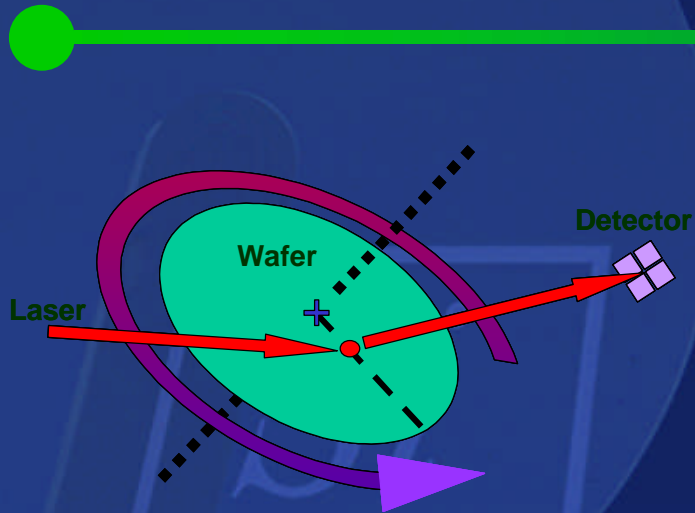
Typical 100 mm 4HN-SiC
Wafer MPD $\sim 0.6 \text{ cm}^{-2}$



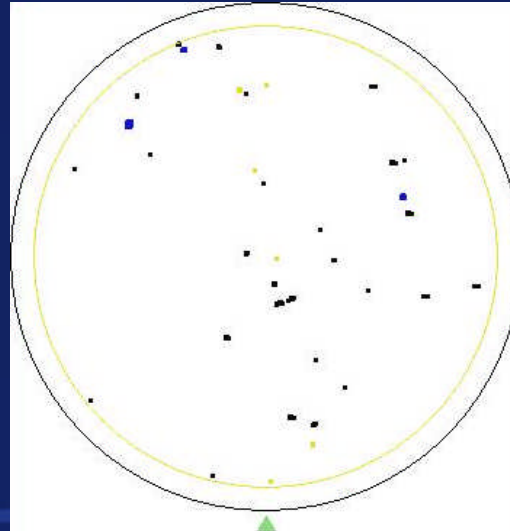
Micropipe Free
100 mm 4HN-SiC Wafer



SiC Substrate and Epi Defect Mapping For Enhanced SiC Device Yield

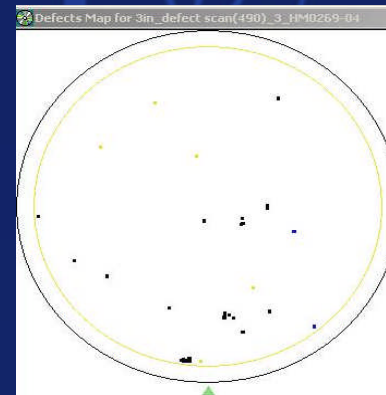


**Candela Tool For Automated
SiC Material Defect Mapping**



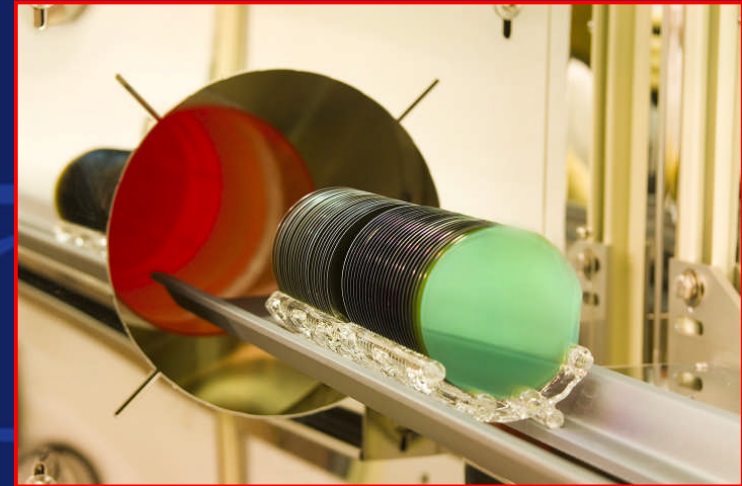
- **Predicted “Material” Yield for 8x8 mm SiC JBS Diodes = 63%**
- **Measured Yield for 10.6 x 8.3 mm SiC JBS Diodes = 72%**

	0	0	0	0	1	
0	0	0	0	0	0	0
0	0	0	0	0	0	0
0	0	0	1	4	0	0
1	0	0	0	0	1	0
1	0	0	0	0	0	0
	0	1	2	3	1	

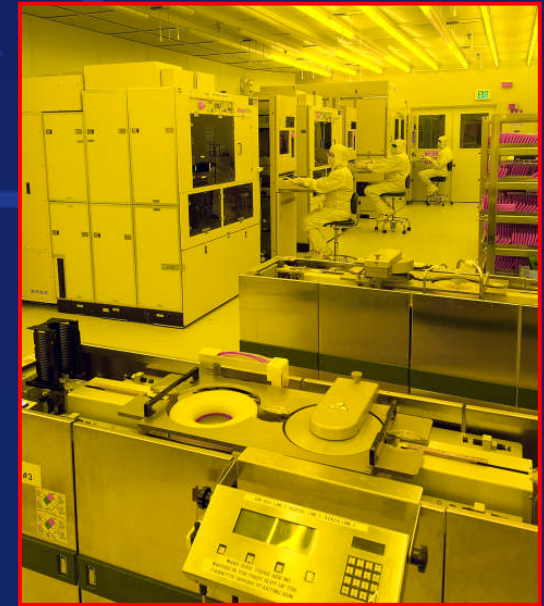


- **Predicted “Material” Yield for 8.1x8.1 mm SiC DMOSFETs = 77%**

Cree WBG Technology Center of Excellence



- **Opened August 2006 For Large-Scale Commercial Production And Advanced Research in WBG Power and RF Products**
- **Located in Research Triangle Park (RTP), North Carolina**
- **Worlds Largest Dedicated WBG Production Device Facility**
 - 40,000 total sq. ft.
 - WBG Device Fabrication Capacity: 10K Wafer Starts per Year
 - SiC Power Device Characterization & Reliability Labs
 - SiC Power On-wafer Probe and Dice
 - SiC Power Applications Support



Cree's SiC Power Product Roadmap

- SiC Power Products

- *ZERO RECOVERY™* Rectifiers –

- SiC JBS Diodes
 - 300V – 10A to 20A
 - 600 V – 1A to 20A
 - 1200V - 5A to 50A
 - 10kV/10A - Product Development

- SiC PiN Diodes

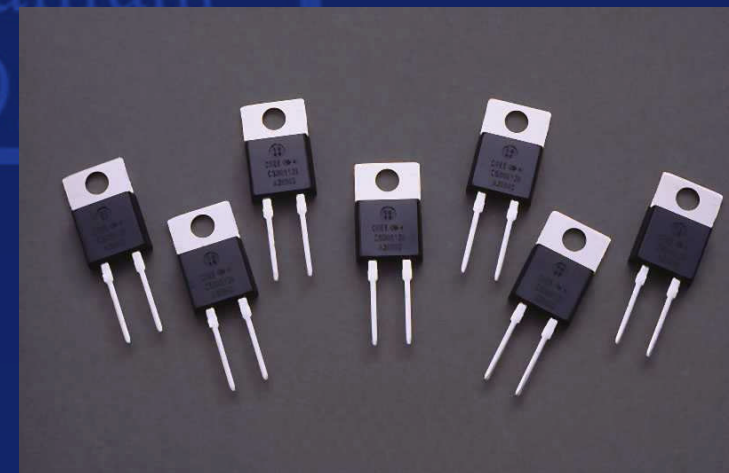
- > 2400V - Product Development

- SiC DMOSFETs

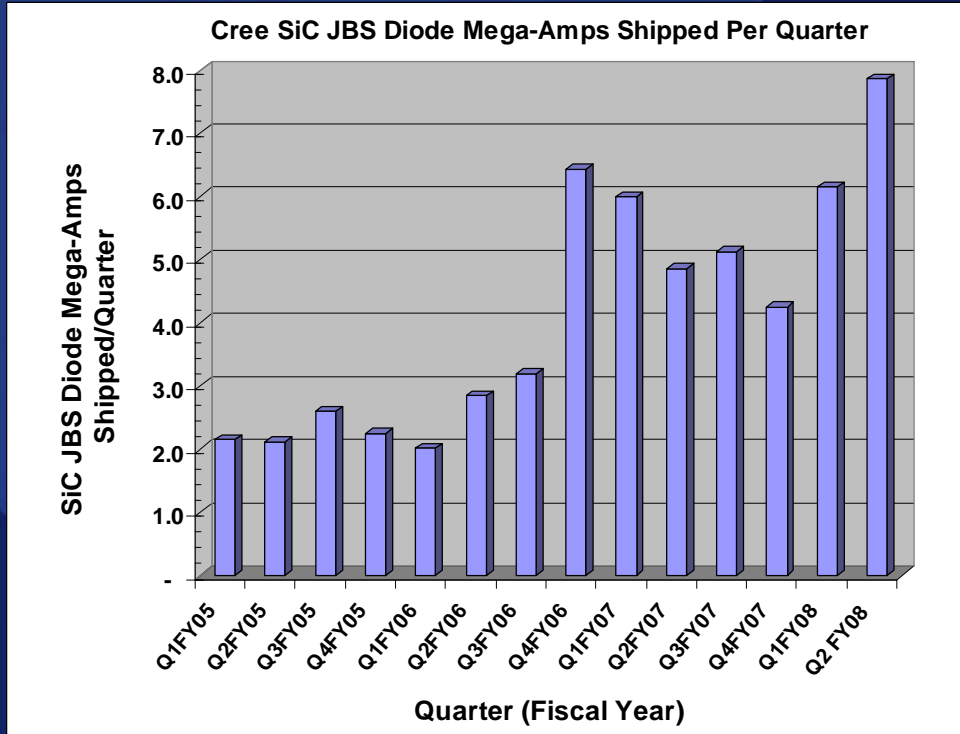
- 1.2kV – 10kV / 10A - 67A
 - Product Development

- SiC IGBTs

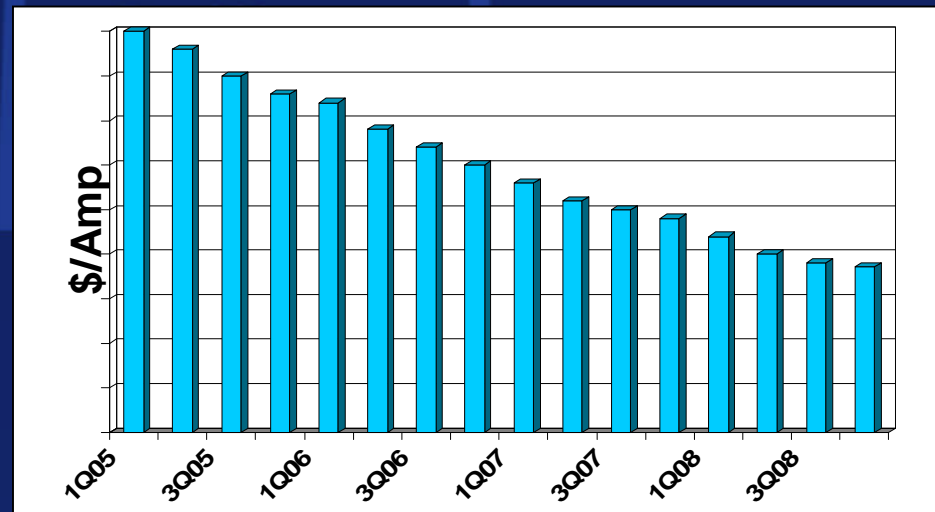
- ≥ 12 kV - Advanced Development



Growth in Commercial Production of SiC JBS Diodes at Cree

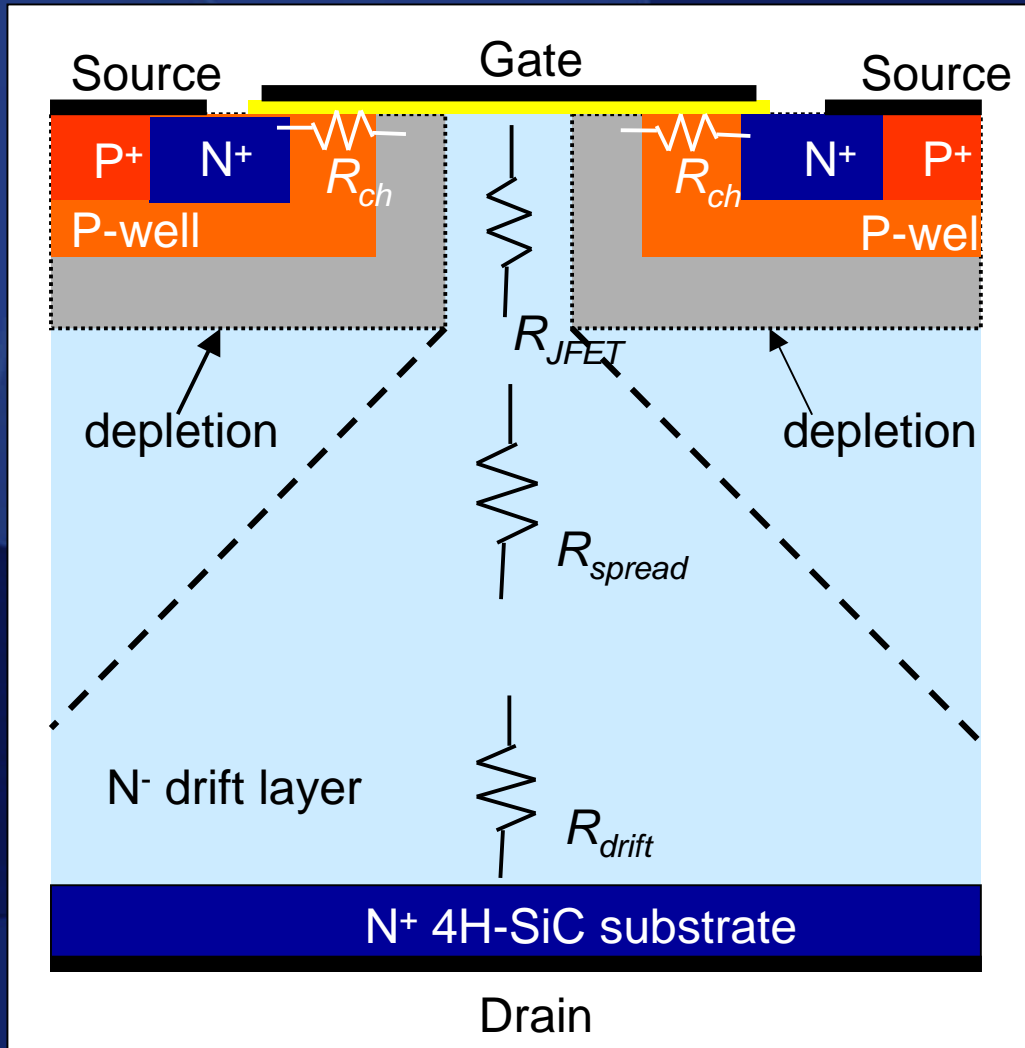


- Over 2x Reduction in Price of SiC JBS Diode – 3 Factors
 - Higher Quality SiC Material
 - Larger Production Volumes
 - Increase SiC Wafer Size From 3 inch to 100 mm Diameter



In Q2-FY08 (Ending 12/07) Cree Shipped **7.8 Mega-Amps** of SiC JBS Diodes

Double Implanted MOSFET (DMOSFET)



Pursuing DMOSFET
As Power Switch
From 1.2kV Up To 10kV

DMOSFET Requirements

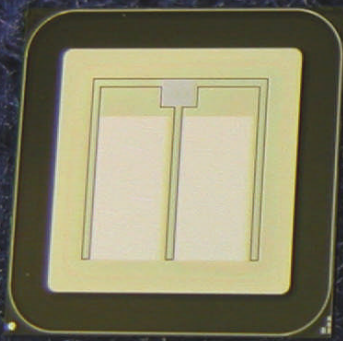
- Low $R_{on,sp}$
- High Switching Speed
- Manufacturable Design/Process
- Acceptable Reliability

Scaling of SiC DMOSFET Technology

2008

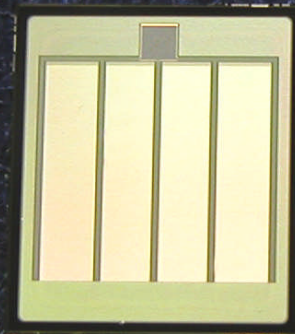
2004

8.11 x 8.11 mm²



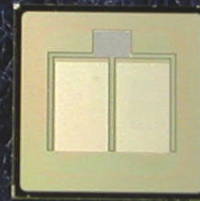
10kV / 10A

8 x 7 mm²



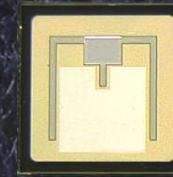
1.2kV / 67A

4.7 x 4.7 mm²

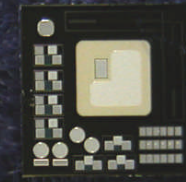


1.2kV / 20A

3.63 x 3.63 mm²



1.2kV / 10 A



1.2kV / 2 A



Creating Technology That Creates Solutions

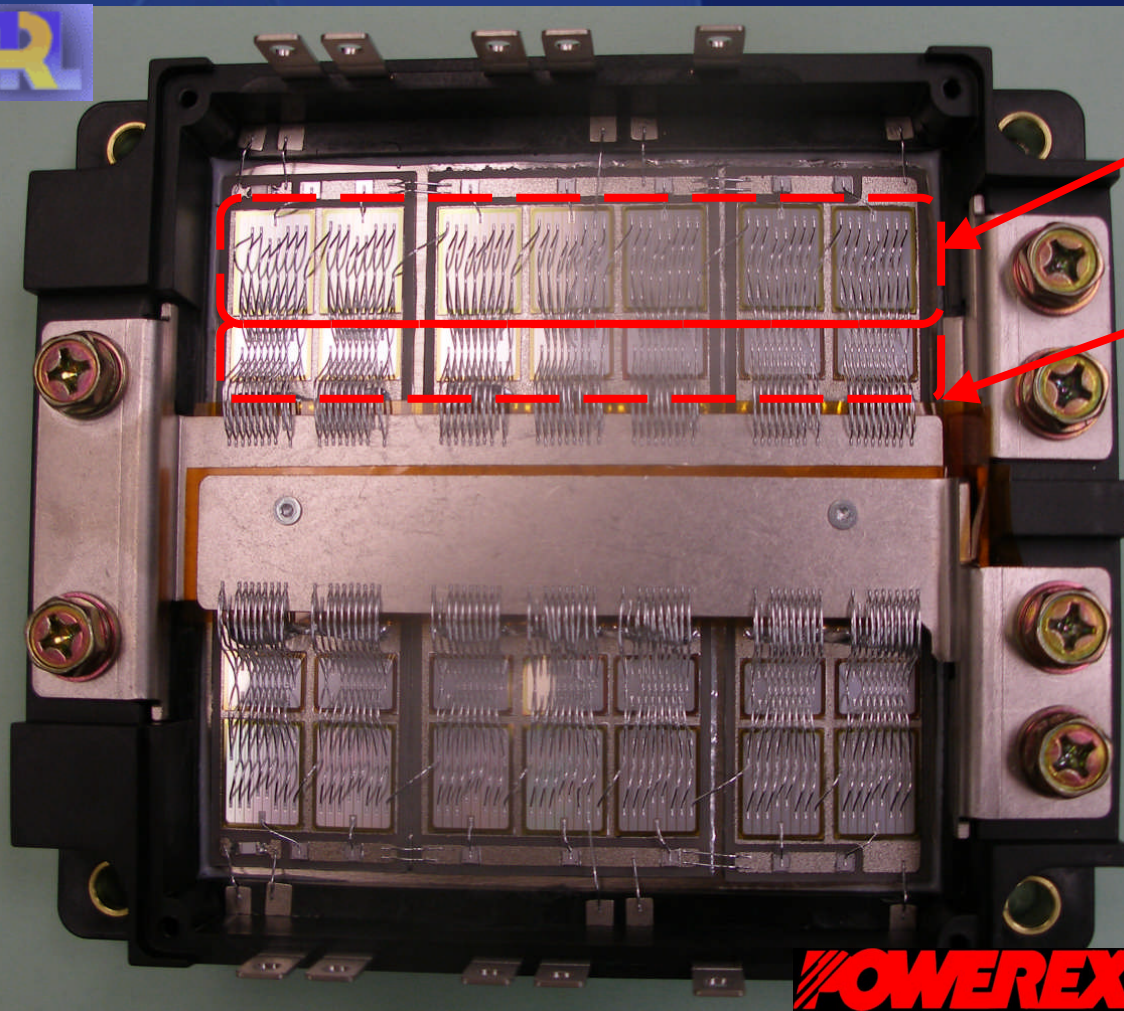


SiC MOSFET Power Module for FCS Hybrid Electric Vehicle (HEV) Propulsion



All SiC 1.2kV / 1400A Power Module

$R_G = 0.5 \text{ ohm}$, $f = 10 \text{ kHz}$



Replace Si IGBT with SiC MOSFET =>
40% Reduction in Loss

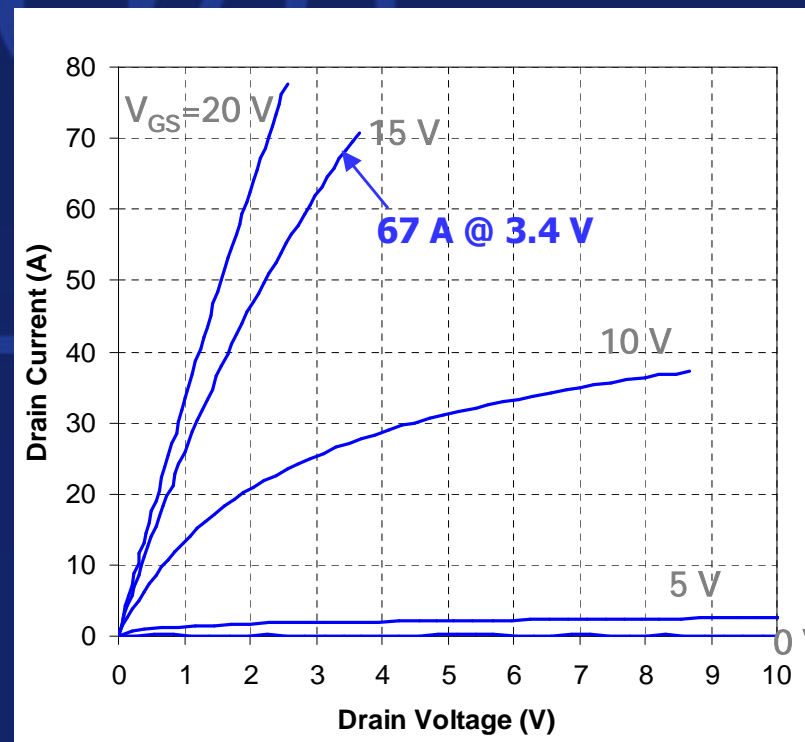
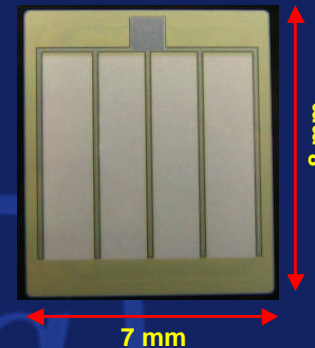
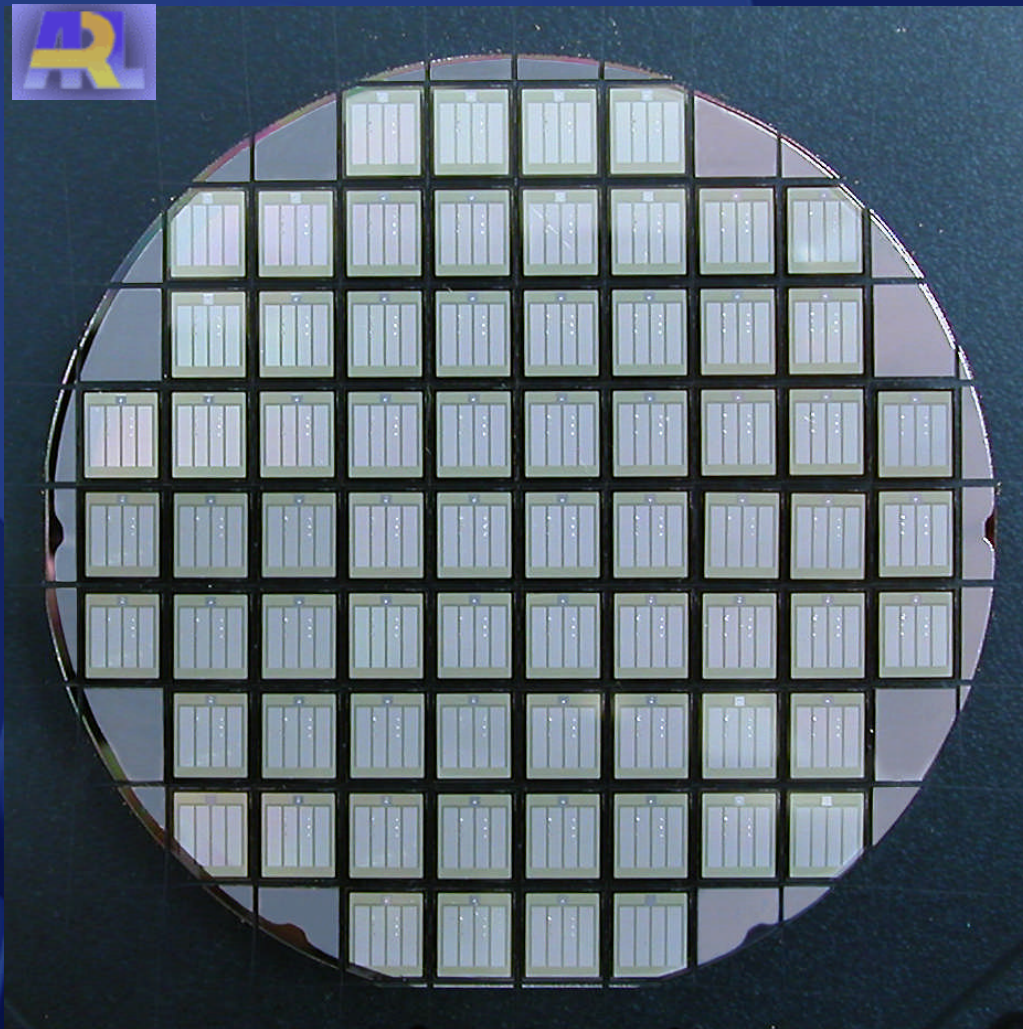
Replace Si diode with SiC JBS Diodes =>
20% Reduction in Loss

> 2x Reduction in Converter Losses
+
150 °C Operating Temperature (Si = 125 °C)

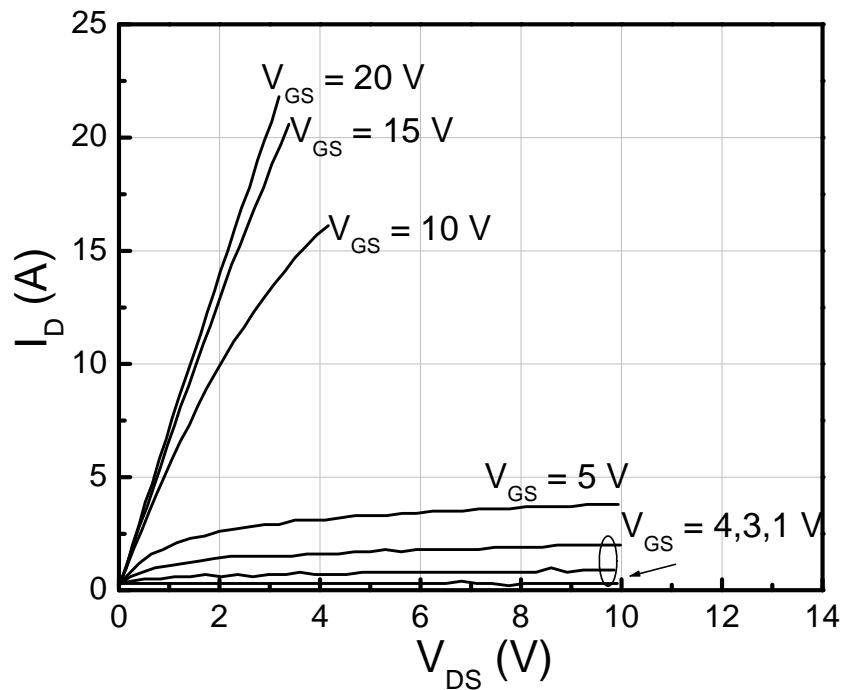
> 4x Reduction in Cooling Requirements



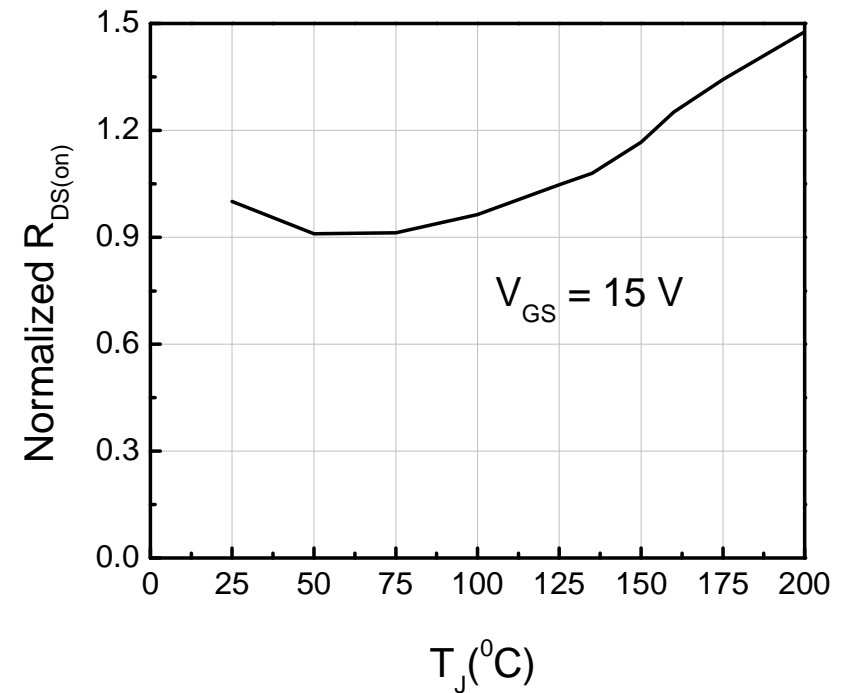
1.2kV/67A SiC DMOSFETs Fabricated on 3-Inch 4HN-SiC Wafer



High Temperature Device Characteristics For 1.2kV/10A SiC DMOSFETs



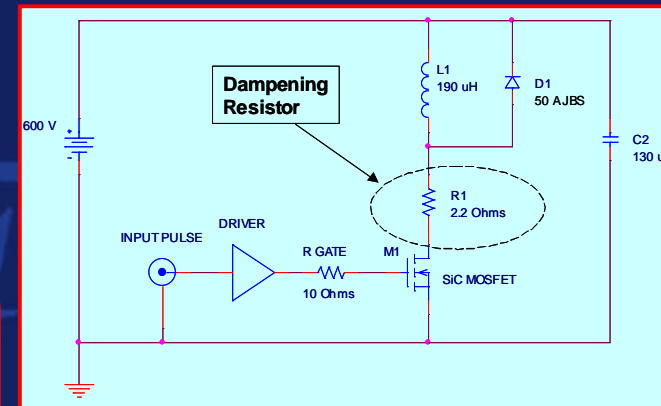
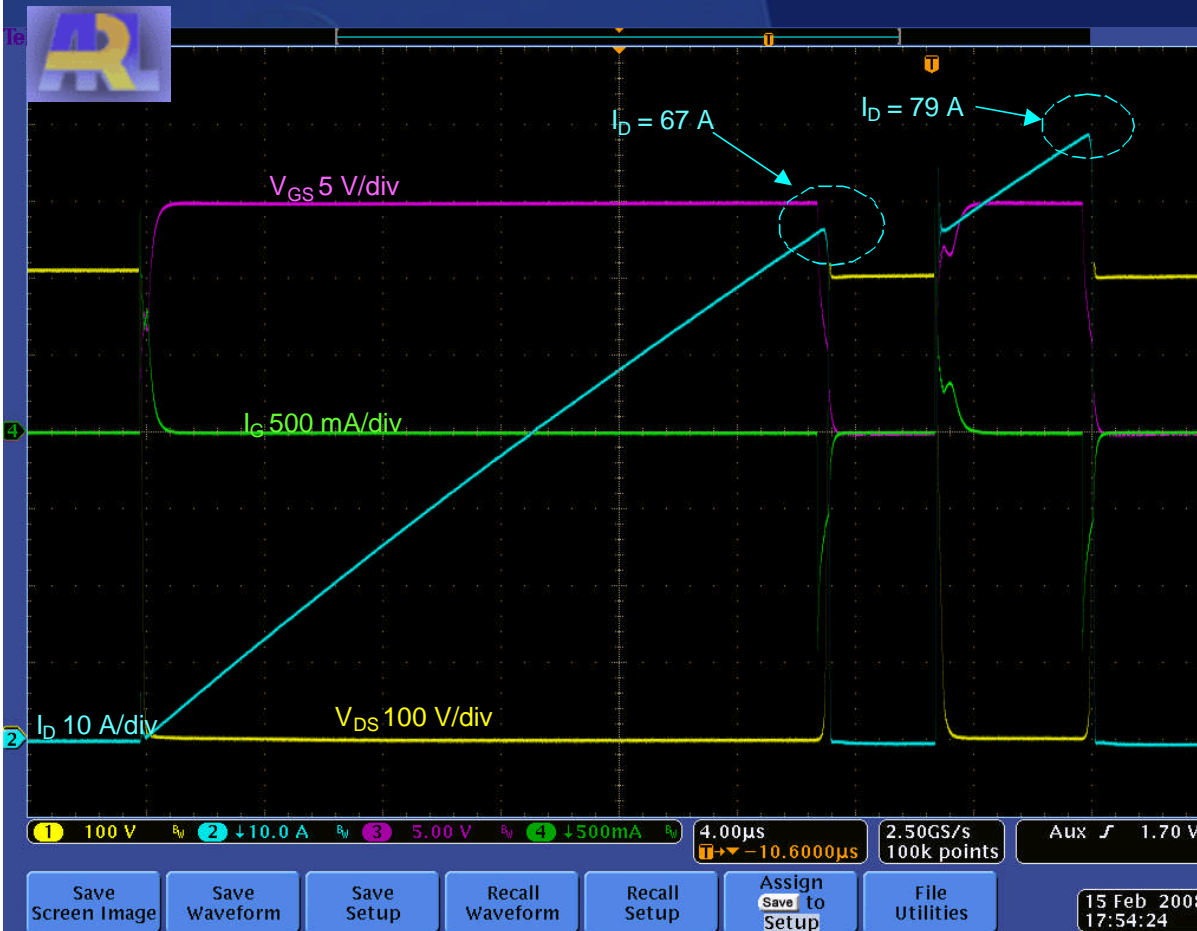
Typical Output Characteristics $T_J = 150^\circ\text{C}$



Normalized On-Resistance vs. Temperature



1.2kV/67A SiC DMOSFET Switching Measurements at 150 °C



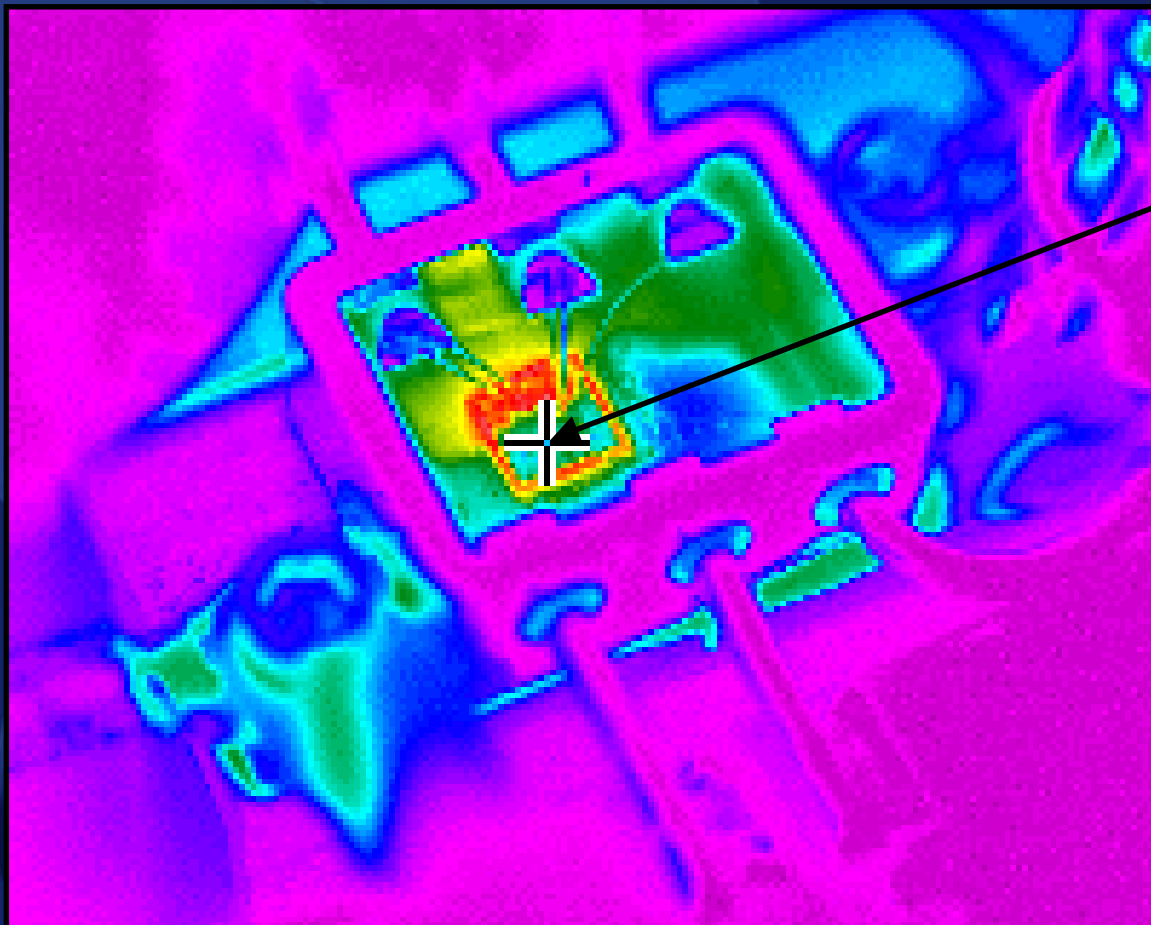
$V_{DS} = 600$ V

• 1.2kV/67A SiC DMOSFET Switching 67A at 150°C

- $E_{on} = 4.2$ mJ
- $T_{rise} = 65$ nsec
- $E_{off} = 3.1$ mJ
- $T_{fall} = 68$ nsec



Boost Converter Demonstration of 1.2kV/10A SiC DMOSFET High Temperature Operation



- Thermograph Demonstrates **1.2kV/10A SiC DMOSFET High Temperature Operation (> 183 °C)** Under Hard Switching Conditions
- 1.2kV/10A SiC DMOSFET Junction Temperature > 183 °C for 12 hrs
 - No failures
 - Stable operation



CREE 

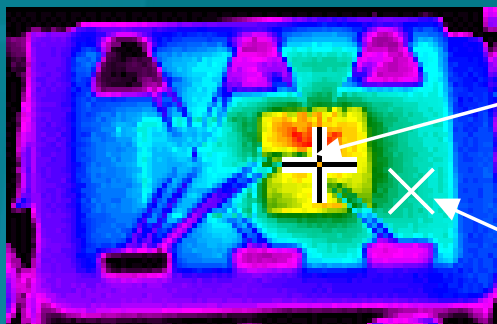
Creating Technology That Creates Solutions



Excellent Current Sharing of Parallel 1.2kV/10A DMOSFETs in Boost Converter



Single 1.2kV/10A SiC DMOSFET Operating @ 10.7 A RMS

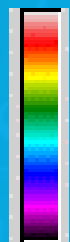


$T_J = 215\text{ }^\circ\text{C}$

$T_C = 195\text{ }^\circ\text{C}$

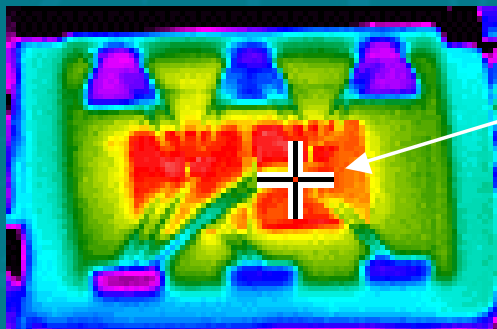
Scale

227.2 °C



149.6°C

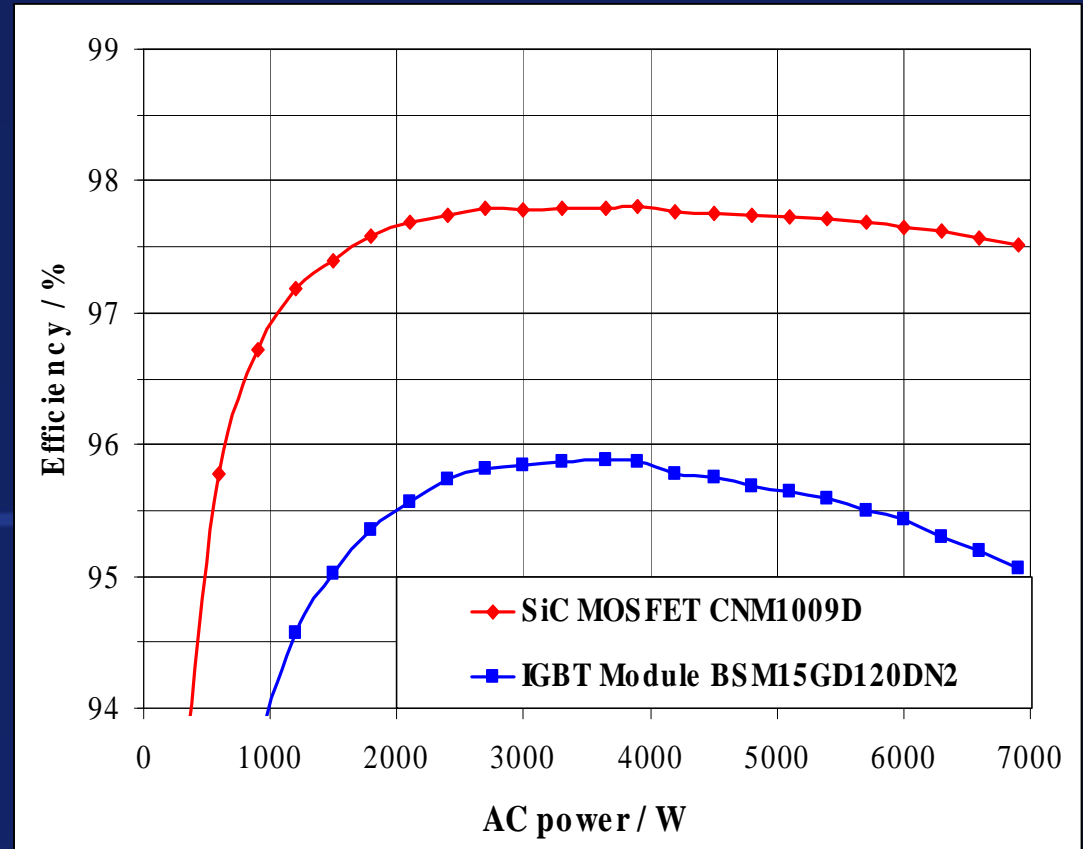
2x Parallel 1.2kV/10A SiC DMOSFETs Operating @ 15.7 A RMS



$T_J = 218\text{ }^\circ\text{C}$

SiC 1.2 kV DMOSFETs Dramatically Improve Efficiency of 3-Phase 7kW Solar Inverter

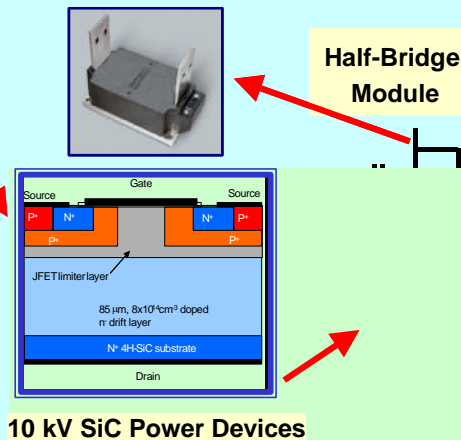
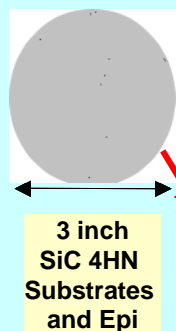
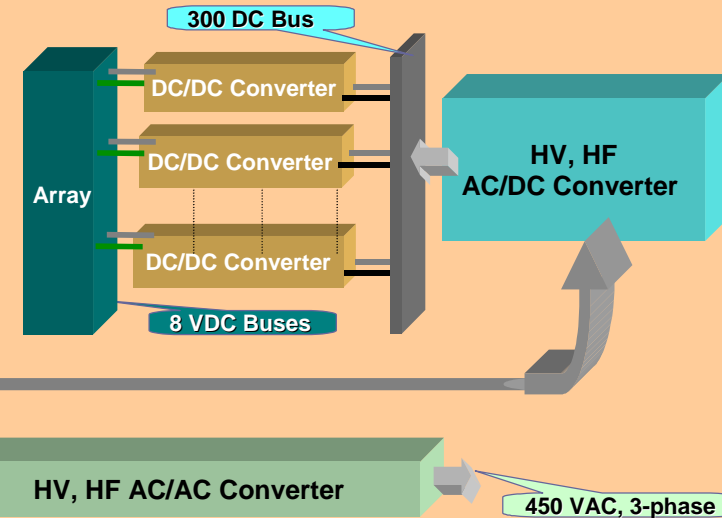
- Dr. Bruno Burger at Fraunhofer-Institute for Solar Energy Systems – 9/07
- Replaced Si IGBTs with 1.2kV SiC DMOSFETs In Existing Solar Inverter Without Further Optimization
- **Efficiency Increased by 2.36%**
- Huge Impact on Market - Typically Struggle for Tenths of a Percent Improvement



DARPA HPE High Power SiC Module Development



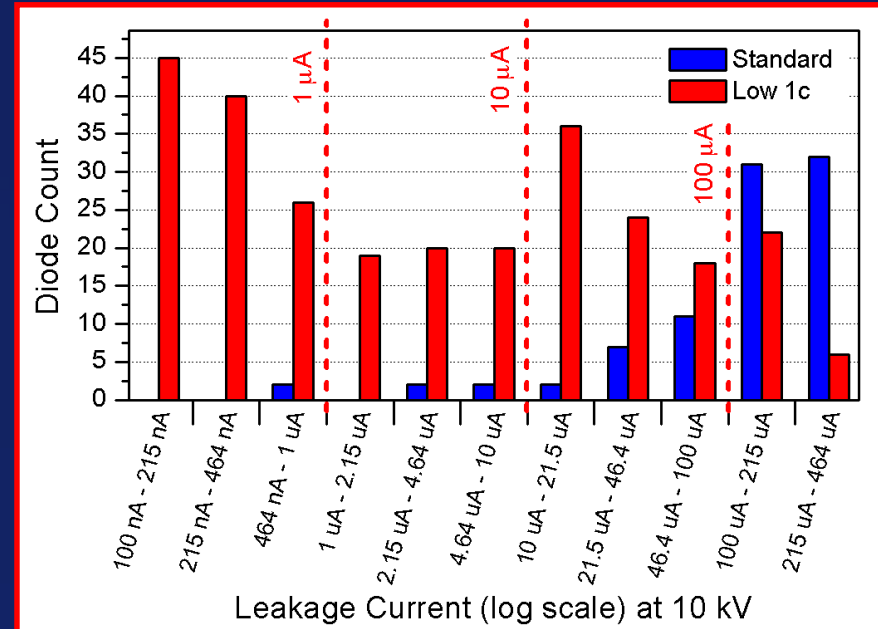
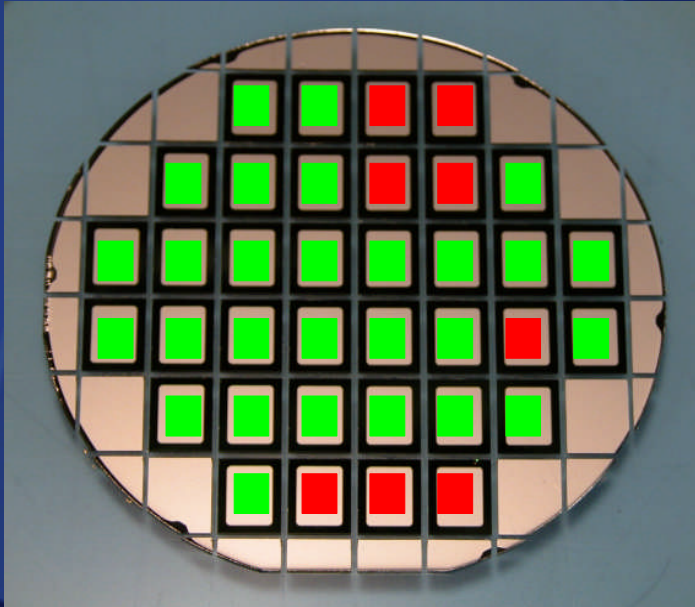
- Develop SiC-Based Power Module for Solid State Power Substation (SSPS)



- CVN-78 Power Distribution Uses 2.75 MVA/60HZ Power Transformers – Each Weighing Several Tons
- Develop SiC Power Module for Replacement SSPS 2.75 MVA 3-Phase Converter - 13.8kV AC to 465 AC
- Reduce System Weight by Factor of 10x
- Reduce System Size by Factor of 3x
- Demonstrate Comparable Efficiency ~ 97%



High Yield Fabrication of 10kV/10A SiC JBS Diodes

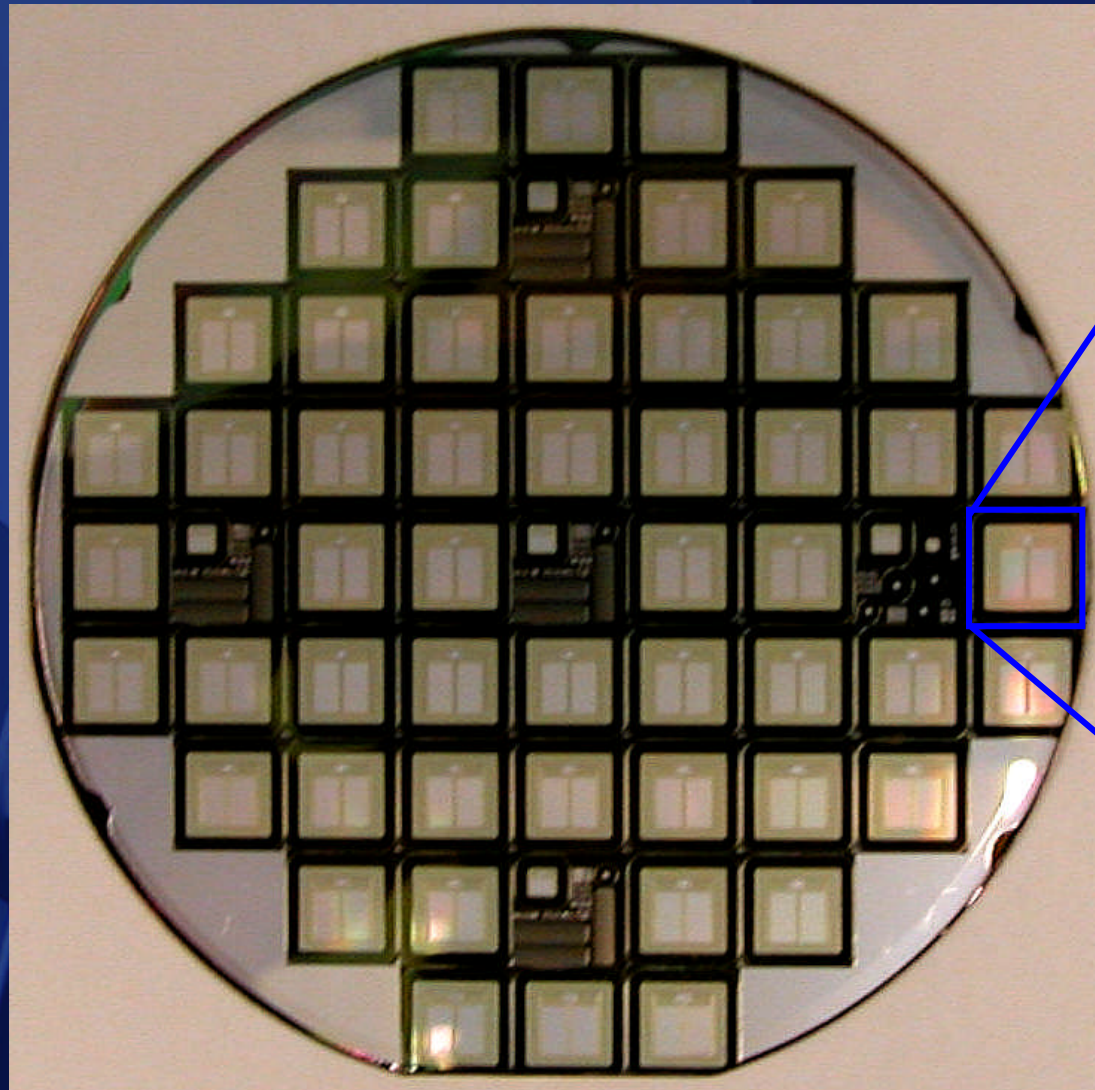


Reverse Leakage Current Histogram of 10kV/10A SiC JBS Diodes

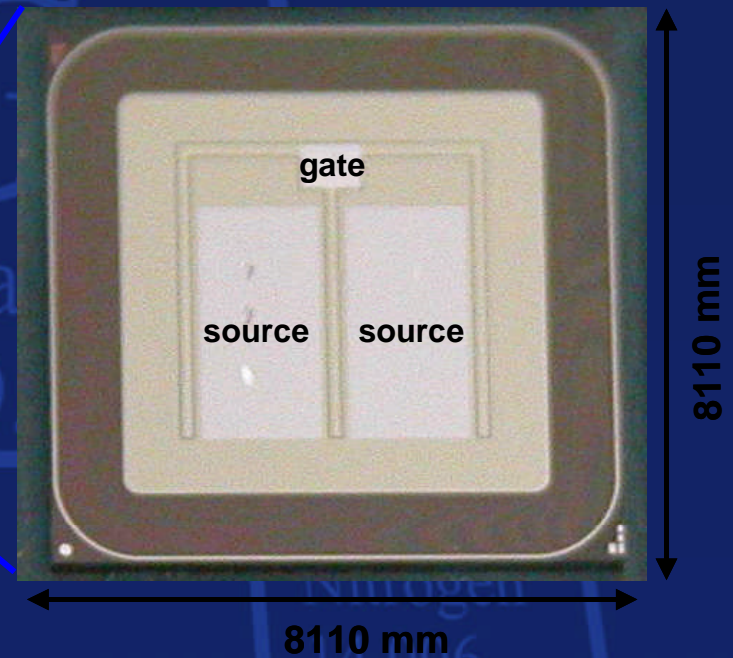
- High Yield Fabrication of 10kV/10A SiC JBS Diodes on 3-inch Wafers
 - Highest Yield = 78%
 - Green \Rightarrow Good Device on 3-inch Wafer

- Low-1c SiC Wafers Dramatically Increase Yield of 10kV/10A SiC JBS Diodes
 - Median Reverse Leakage Current Decreased $> 50X$
 - Device Yield Increased $> 3x$

10kV/10A SiC DMOSFET

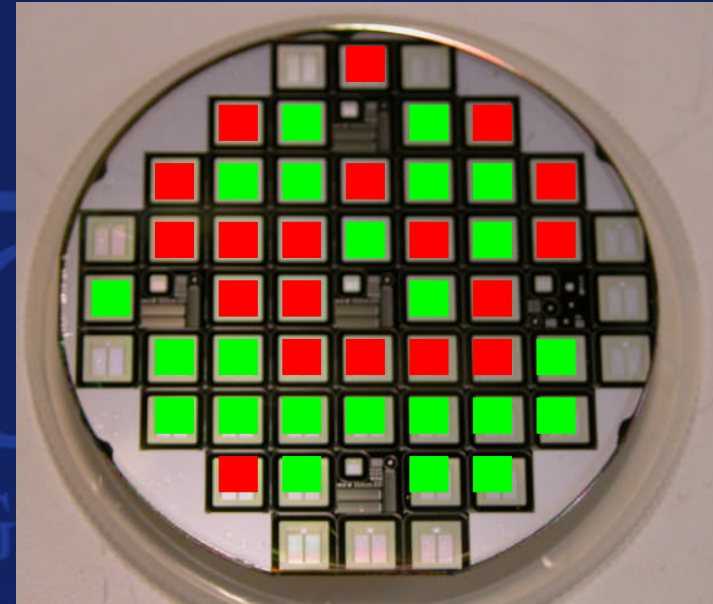
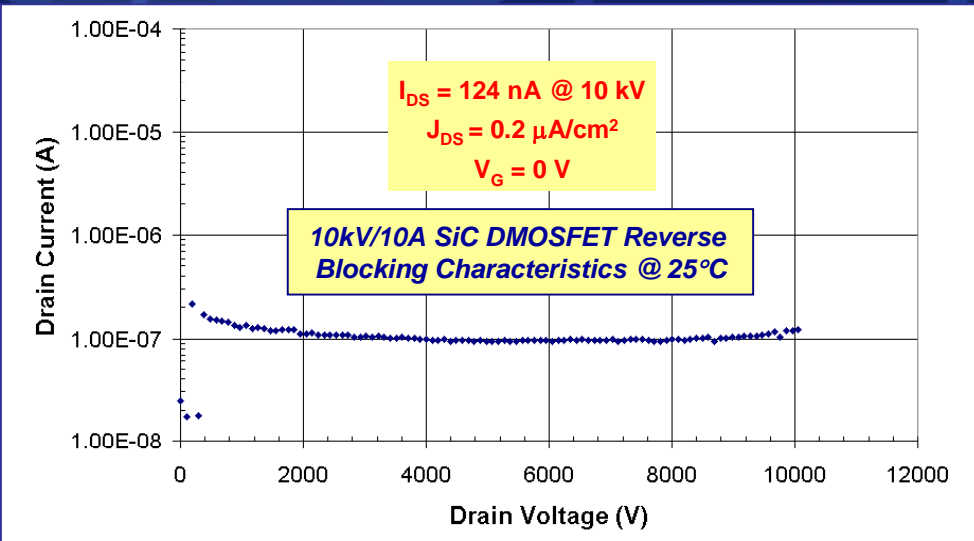
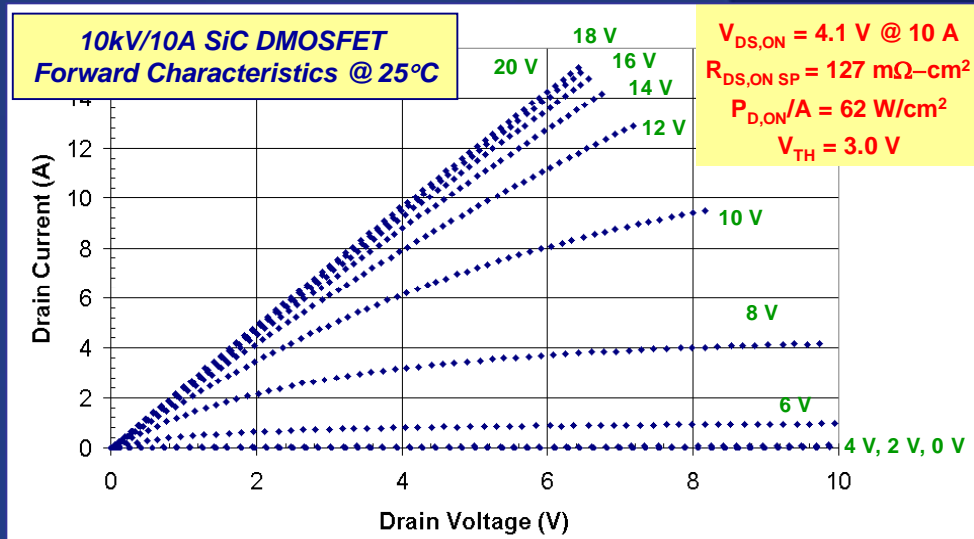


10kV/10A SiC DMOSFETs
52 Die Fabricated on
3-in 4HN-SiC Wafer





High Yield Fabrication of 10kV/10A SiC DMOSFETs

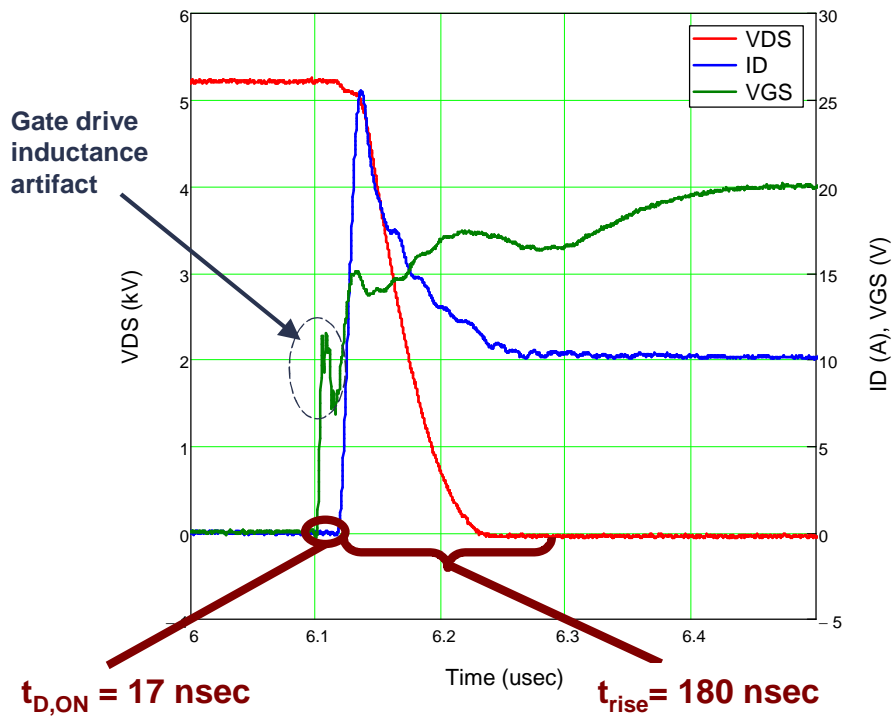


- High Yield Fabrication of 10kV/10A SiC DMOSFETs on 3-inch Wafers
 - Highest Yield = 55%
 - Green \Rightarrow Good Device on 3-inch Wafer

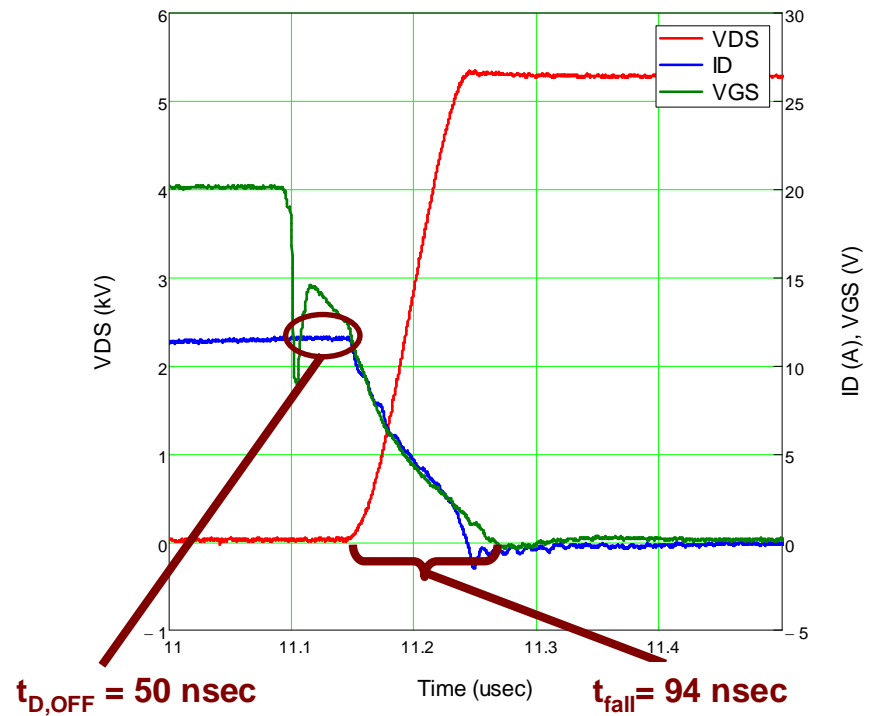


10kV SiC DMOSFET/JBS Diode Clamped Inductive Switching

10 A Turn-On Gate Drive, $V_{GS} = 20\text{ V}$



10 A Turn-Off Gate Drive, $V_{GS} = 20\text{ V}$

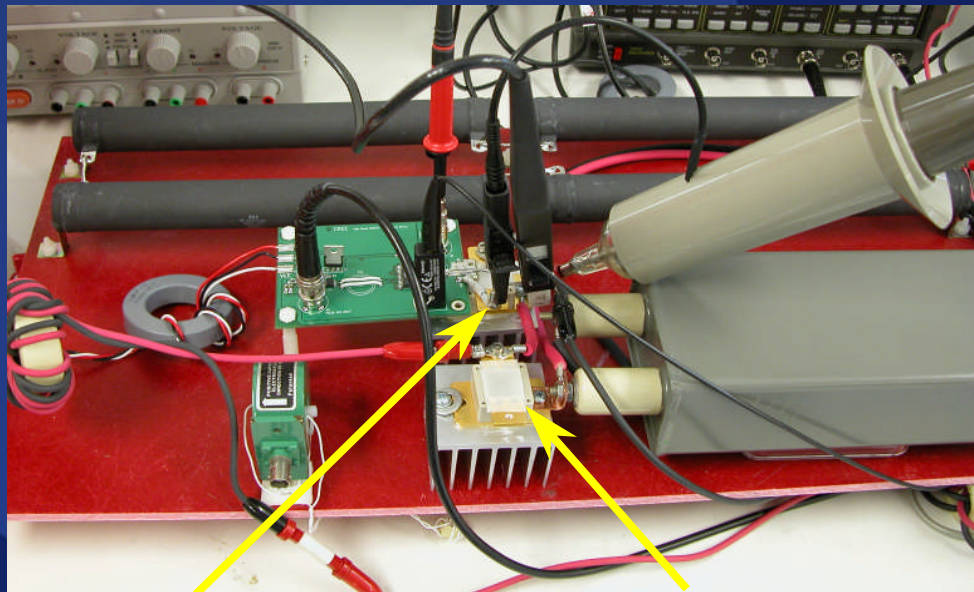


$E_{on} = 4.48\text{ mJ}$

**160 W/cm² Switching Losses
Within Module Thermal Limits**

$E_{off} = 0.81\text{ mJ}$

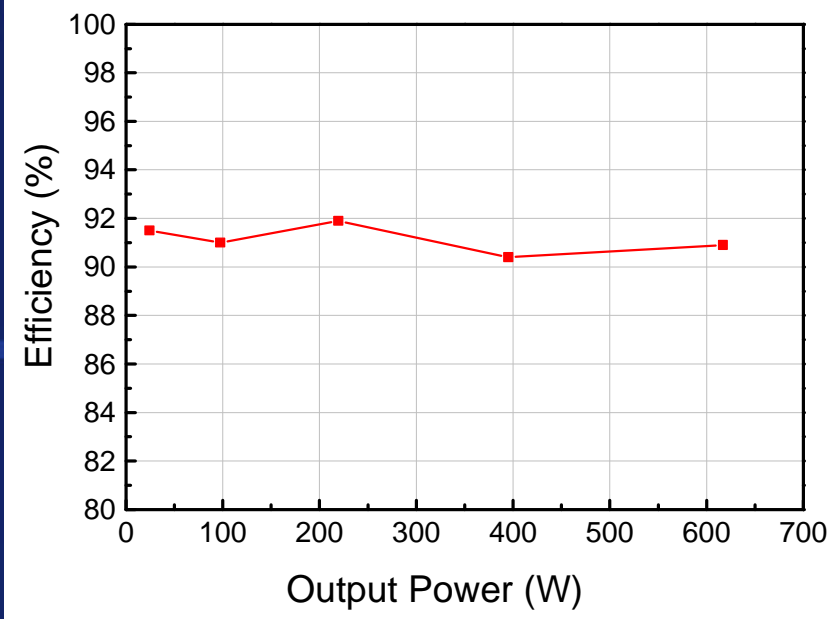
500V – 5kV / 20 KHz Boost Converter Using 10kV/10A SiC DMOSFETs and JBS Diodes



10kV/10A
SiC DMOSFET

10kV/10A
SiC JBS Diode

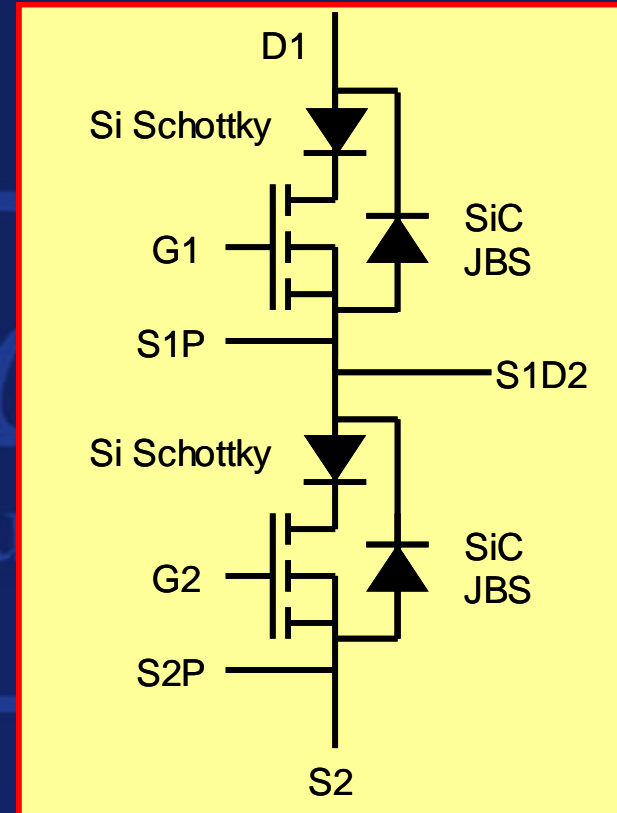
- 500V – 5kV Boost Converter Operating at 20kHz
- Maintained Efficiency > 90% Over Full Load Range



<u>Input</u>	<u>Output</u>	<u>Duty Cycle</u>
$V_{IN} = 503 \text{ V}$	$V_{OUT} = 5 \text{ kV}$	90%
$I_{IN} = 1.35 \text{ A}$	$I_{OUT} = 0.12 \text{ A}$	Operating
$P_{IN} = 679 \text{ W}$	$P_{OUT} = 617 \text{ W}$	at 20kHz



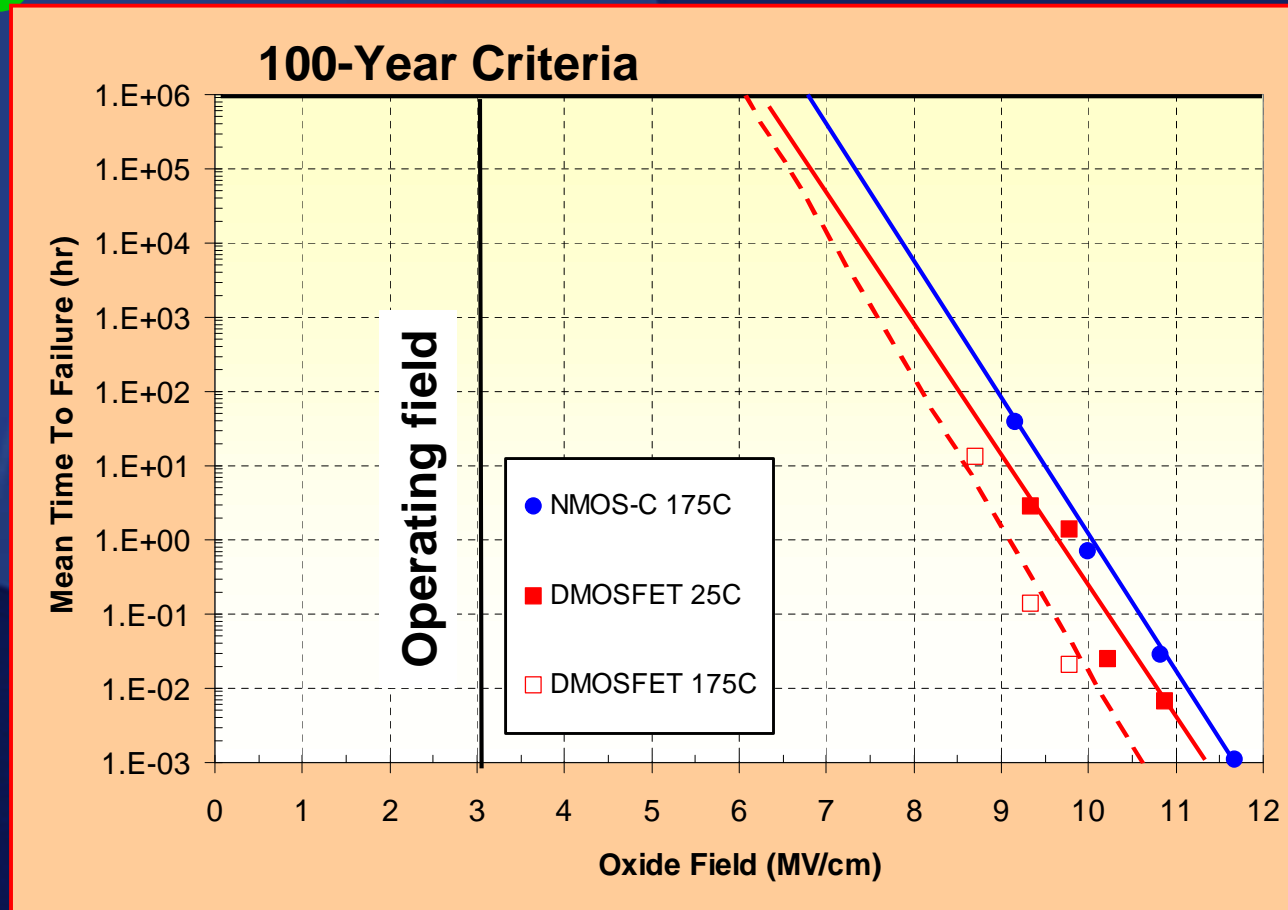
DARPA HPE-II 10kV/50A SiC Half H-Bridge Module



- Each Switch Comprised of 5 Paralleled 10kV/10A SiC DMOSFETs
- Each Rectifier Comprised of 5 Paralleled 10kV/10A JBS Diodes
- 10kV/50A Half H-Bridge Module Only Half Filled
- 10kV Half H-Bridge Module Capable of 100A When Fully Populated



TDDB Measurements of SiC DMOSFET Oxide Reliability



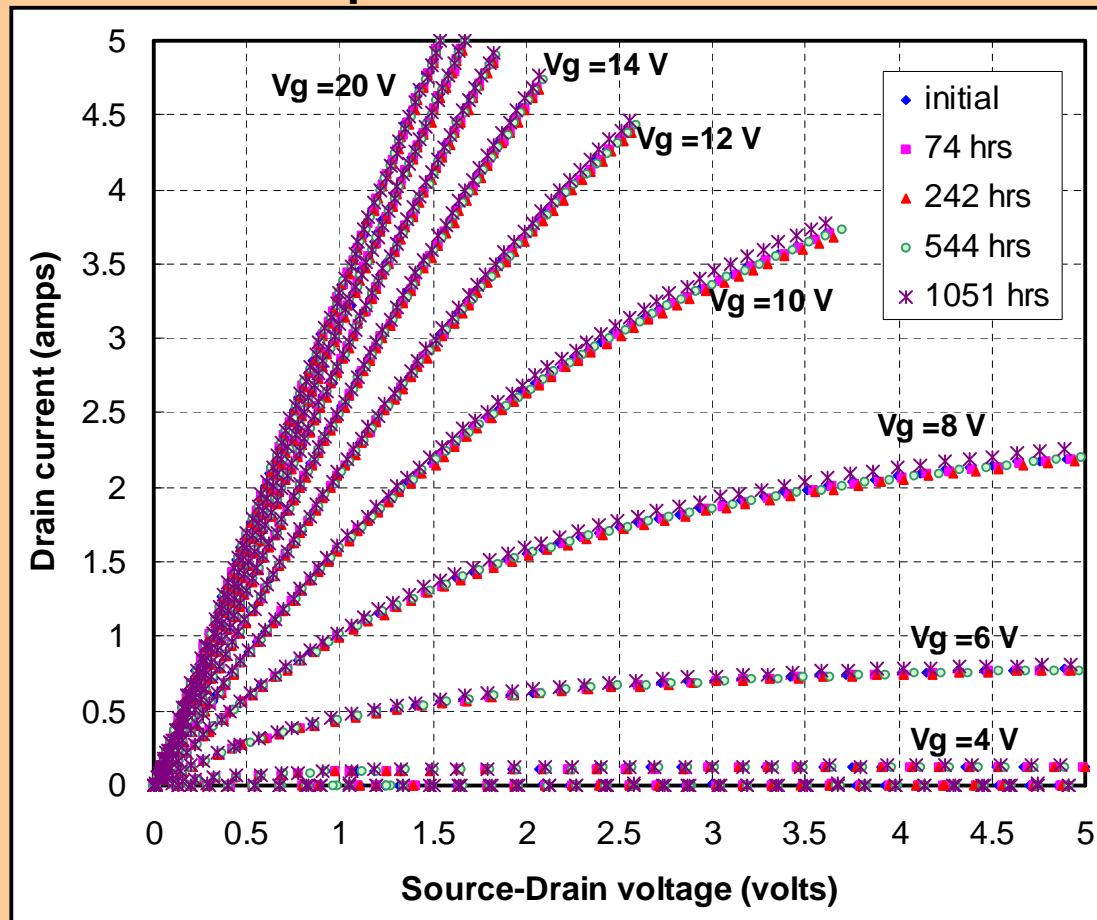
Measurements carried out on smaller DMOSFET devices fabricated without termination.

Device size:
 $4.9 \times 10^{-4} \text{ cm}^2$

- DMOSFETs show acceptable oxide lifetime at an operating field of $\sim 3 \text{ MV/cm}$, despite ion implantation and high temperature annealing

Stability of SiC 1200V/5A SiC DMOSFETs Under Constant Gate Stress at 175°C

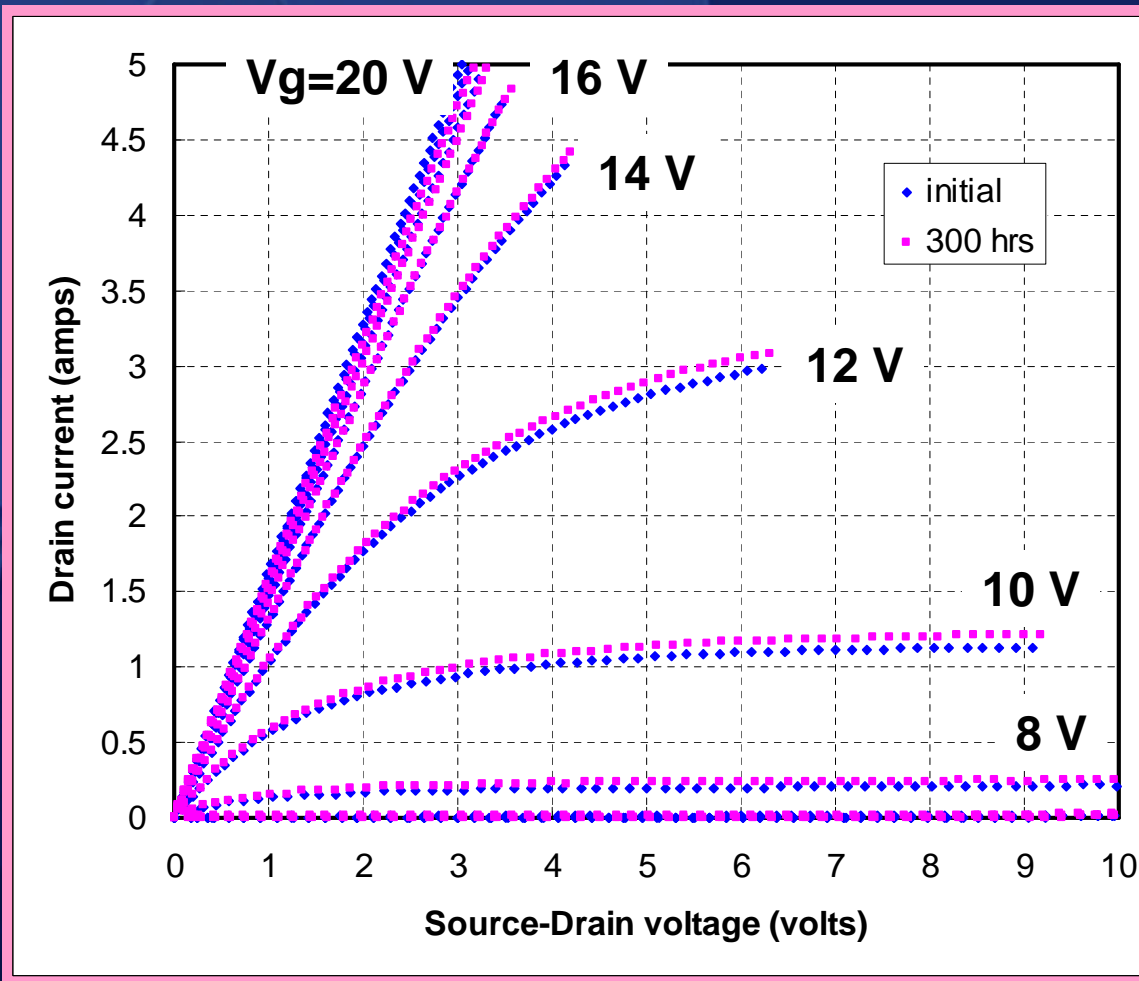
5 A parts – Device size: 0.0753 cm²



- Packaged SiC DMOSFETs Stressed at 175°C for Constant V_g = 15 V With Source & Drain Grounded
- Devices Cooled to RT and remeasured
- SiC DMOSFET I-V Curve Remains Relatively Unchanged After 1050 hrs of Stress

10 kV / 5 A 4H-SiC DMOSFET

High Temperature Gate Stressing

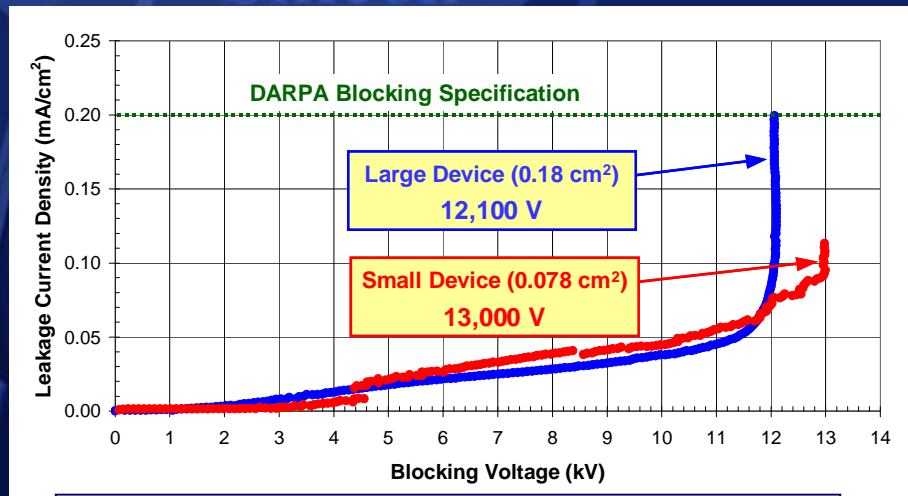
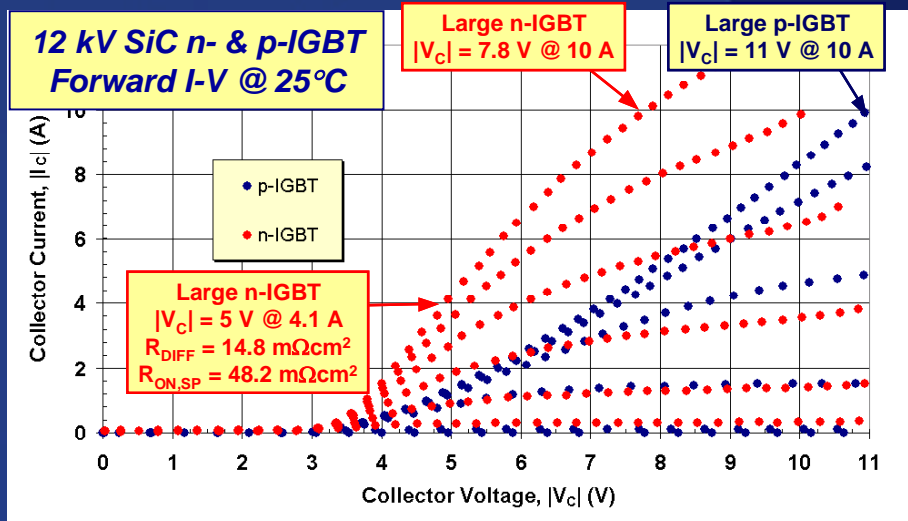


- Packaged DMOSFETs stressed with $V_g = 15V$ at $175^\circ C$, with source and drain grounded
- Devices cooled to RT and measured
- I-V curve remains unchanged after about 300 hrs of stress

What Is Next for SiC Power Devices?

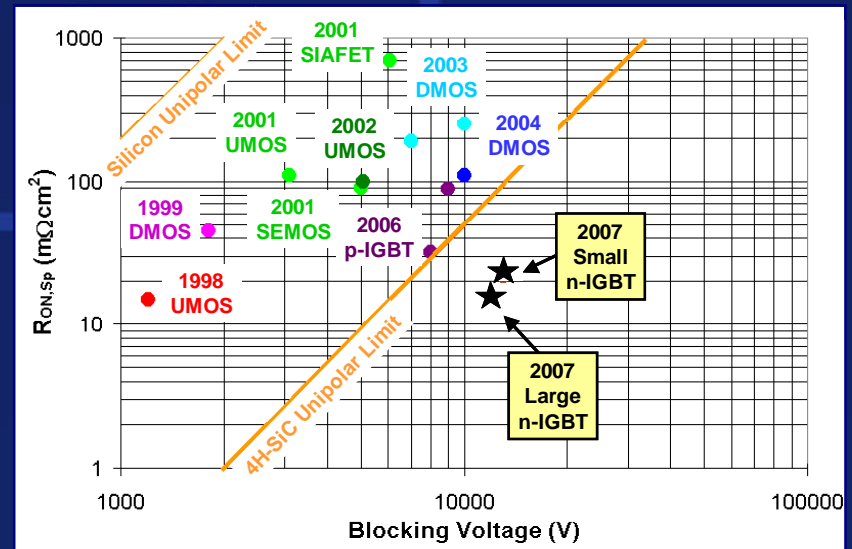
- **10 kV ~ Upper Limit of SiC Unipolar Devices**
 - DMOSFETs and Schottky diodes
- **Higher Voltage \Rightarrow Bipolar Devices**
 - Si IGBT Replace Si DMOSFET at $> 1\text{kV}$
- **For SiC devices, this holds true for $>10\text{ kV}$**
 - SiC breakdown field 10x that of silicon
- **$\Rightarrow >10\text{kV}$ - We Need SiC IGBT**

12kV SiC n-IGBTs and SiC p-IGBTs



• 12kV/10A SiC n-IGBTs and SiC p-IGBTs Demonstrated

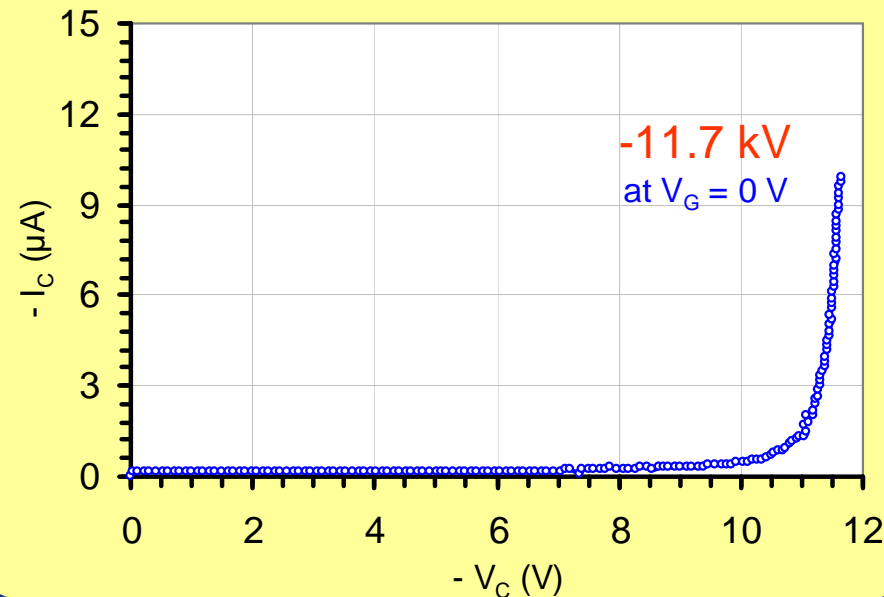
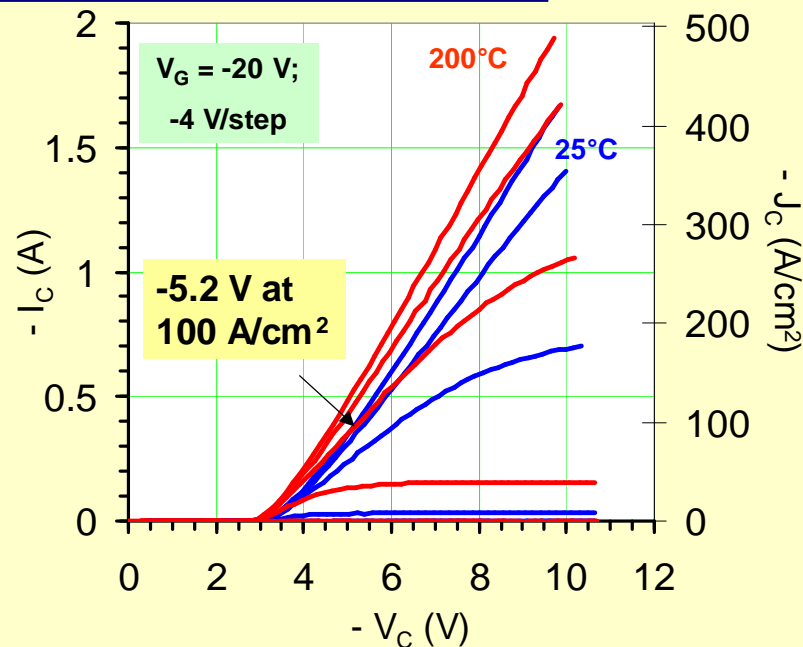
- SiC n-IGBTs Already Beyond $R_{on,sp}/BV$ Limits for SiC DMOSFETs
- \Rightarrow SiC IGBTs Superior to SiC DMOSFETs at $BV > 10\text{kV}$
- n-IGBT ~ n-type SiC drift layer
- p-IGBT ~ p-type SiC drift layer



SiC n-IGBTs Beyond R_{on}/BV Limits for SiC DMOSFETs

12kV SiC p-IGBTs

**12 kV SiC p-IGBT
Forward Characteristics**

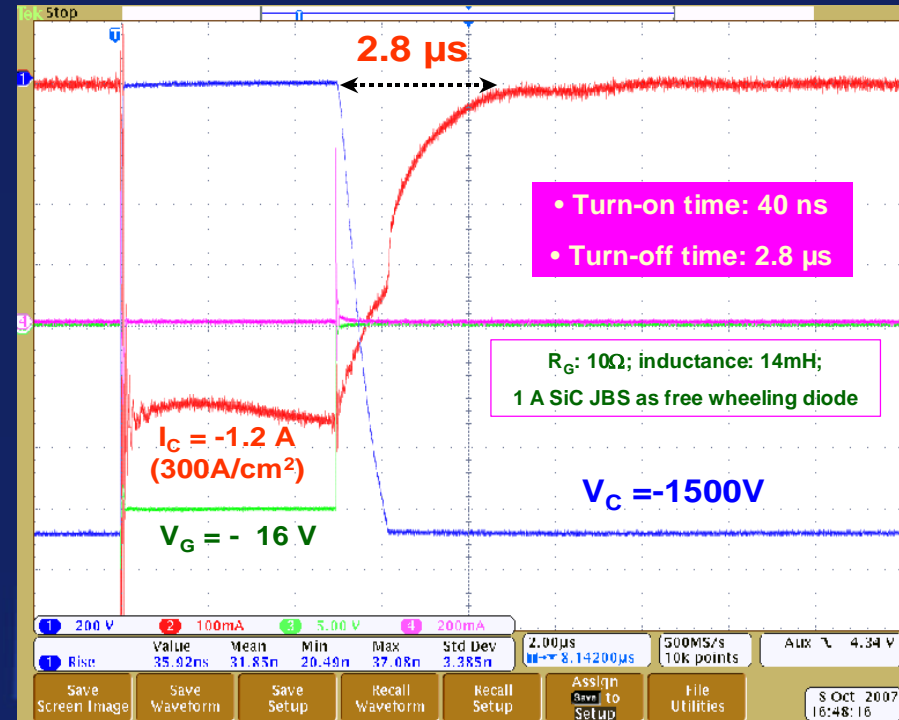
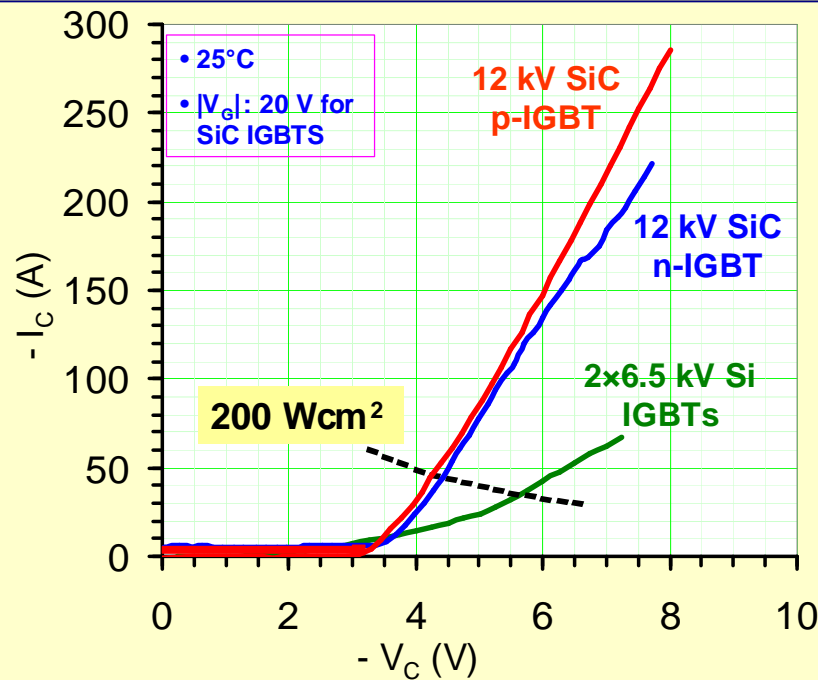


**12 kV SiC p-IGBT Reverse
Blocking Characteristics @ 25°C**

- **12kV SiC p-IGBTs Demonstrated From 25°C to 200°C**
 - 12kV SiC p-IGBT V_f and Current Maintained From 25°C to 200°C
 - ⇒ Reduced Conduction Losses from 25°C up to 200°C
- **SiC IGBTs Offer Advantages over SiC DMOSFETs at Blocking Voltages > 10kV**

Comparison 12kV SiC p-IGBTs and Si IGBTs

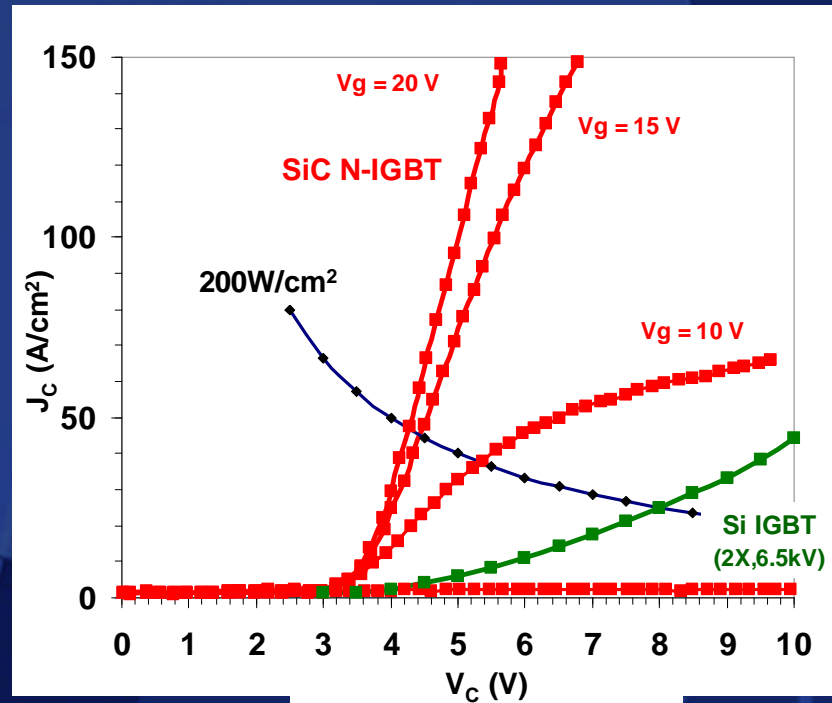
12 kV SiC n-IGBT & p-IGBT Forward Characteristics



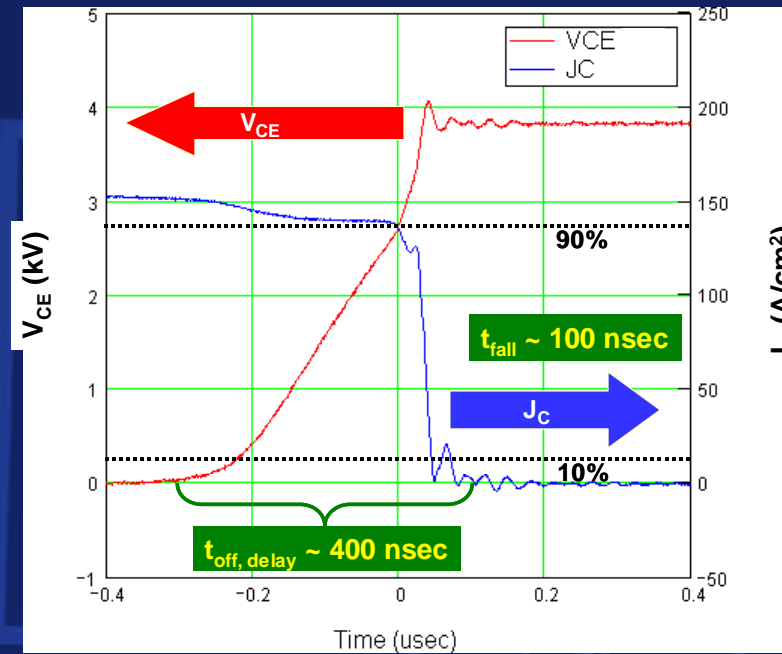
12kV SiC p-IGBT Switching Measurement

- SiC IGBTs Are Superior to Si IGBTs at Higher Voltages
 - Much Lower Forward Voltage (V_F) & Higher Current Rating for Given Blocking Voltage
 - Dramatic Increase in Switching Speed – 12 kV SiC p-IGBT Turn-Off Time < 3 μ s

Comparison of SiC n-IGBTs and Si IGBTs



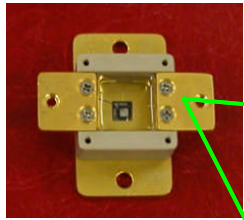
12kV SiC n-IGBT Switching Measurement



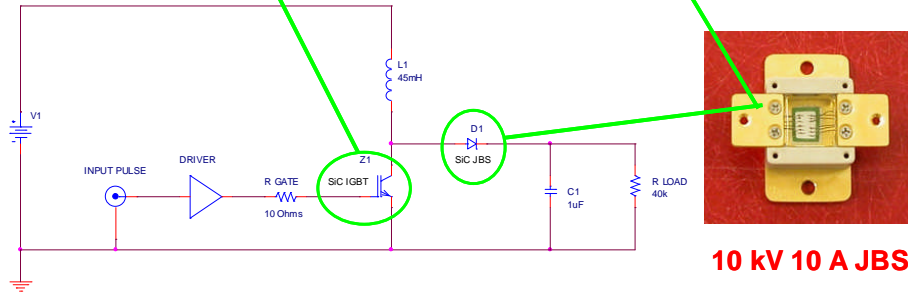
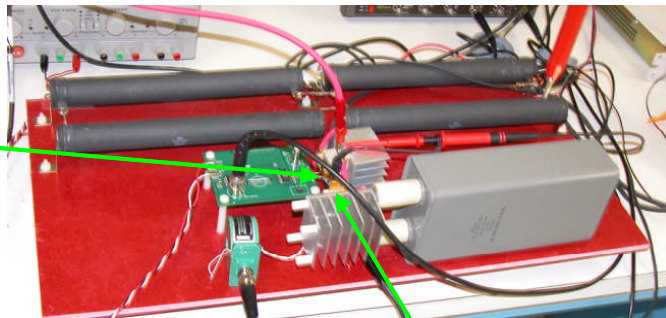
- **SiC IGBTs Are Superior to Si IGBTs at Higher Voltages**

- 12kV SiC n-IGBTs Have >3x Lower $R_{on,sp}$ Than 6.5kV Si IGBTs
- SiC n-IGBTs Have Much Lower Forward Voltage (V_F) & Higher Current Than Si IGBTs at Same BV
- 12kV SiC n-IGBTs Have 4x Faster Switching Speed and >4x Lower Switching Loss than 6.5kV Si IGBTs

12kV SiC n-IGBTs Boost Converter



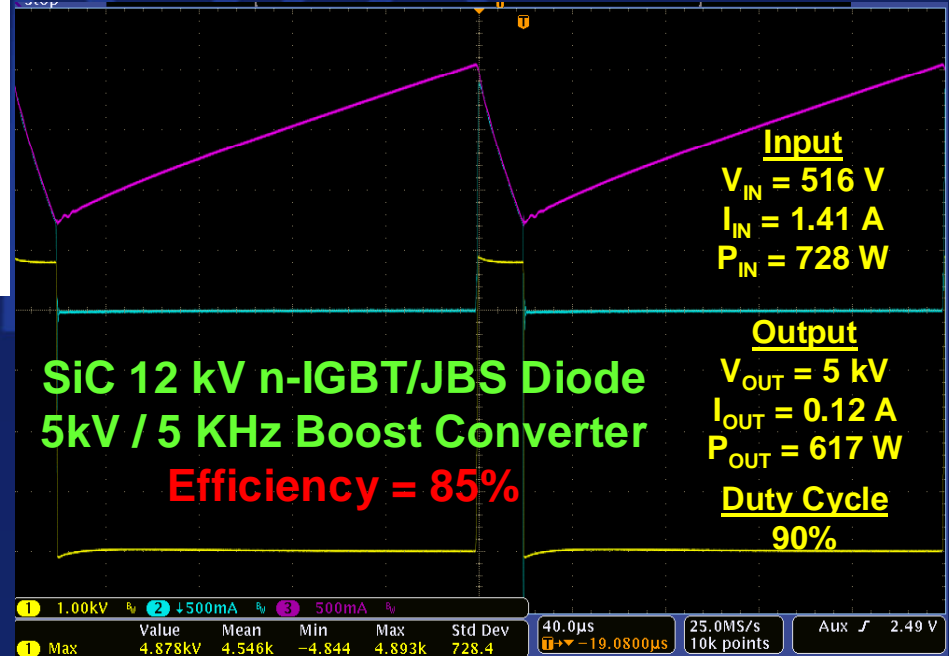
12 kV Large n-IGBT



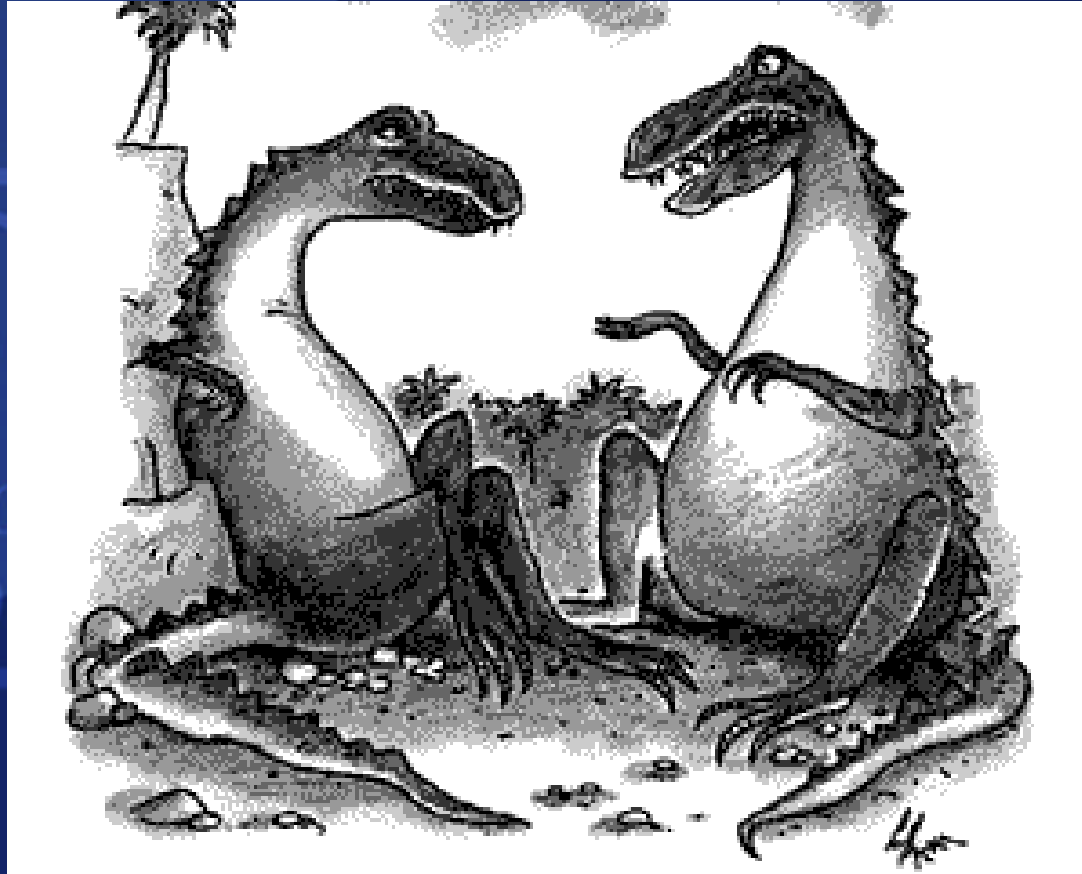
10 kV 10 A JBS

**SiC n-IGBT/JBS Diode
5kV/5KHz Boost Converter**

- 12kV SiC n-IGBTs Used to Demonstrate 5kV/5KHz Boost Converter With 85% Efficiency



Its Time for SiC Power Technology!



“All I’m saying is now is the time to develop technology to deflect the asteroid.”



***Creating Technologies
That Create Solutions***



***Silicon Carbide
The Material Difference***